

International Technology Roadmap for Photovoltaics (ITRPV) 8th edition:

Crystalline Silicon Technology – Current Status and Outlook

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PV Manufacturing in Europe Conference
Brussels, May 19th 2017

Outline



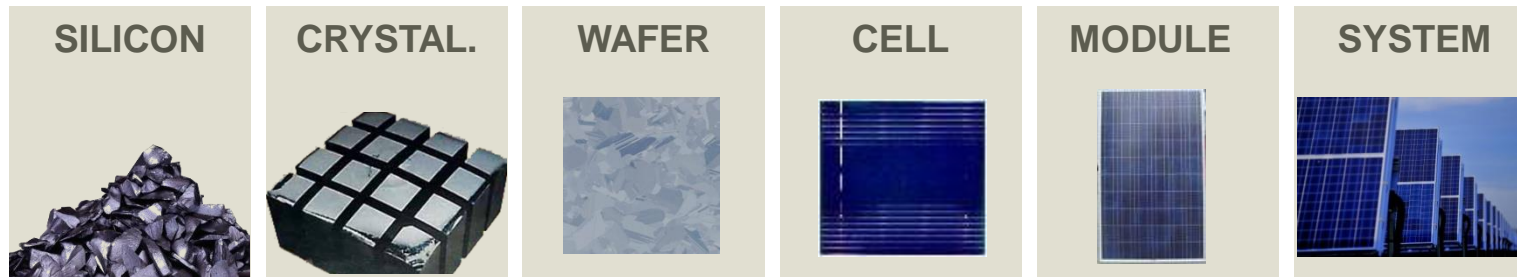
1. **ITRPV Introduction**
2. **PV Learning Curve and Cost Considerations**
3. **ITRPV – Results 2016**
 - **Wafer** - **Materials, Processes, Products**
 - **Cell** - **Materials, Processes, Products**
 - **Module** - **Materials, Processes, Products**
 - **Systems**
4. **Summary and Outlook**

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- 4. Summary and Outlook**

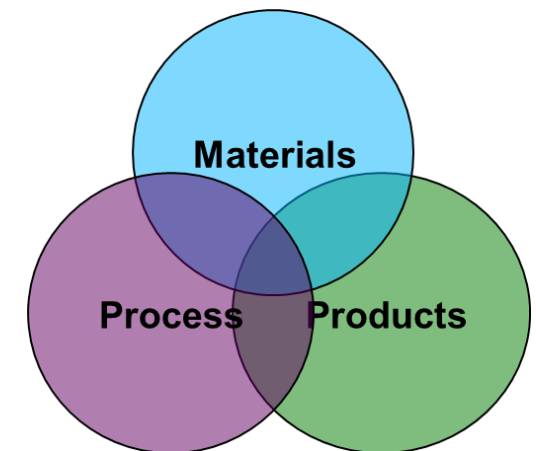
ITRPV – Methodology



Working group today includes 40 contributors from Asia, Europe, and US



Chairs EU
Chairs PRC
Chairs TW
Chairs US

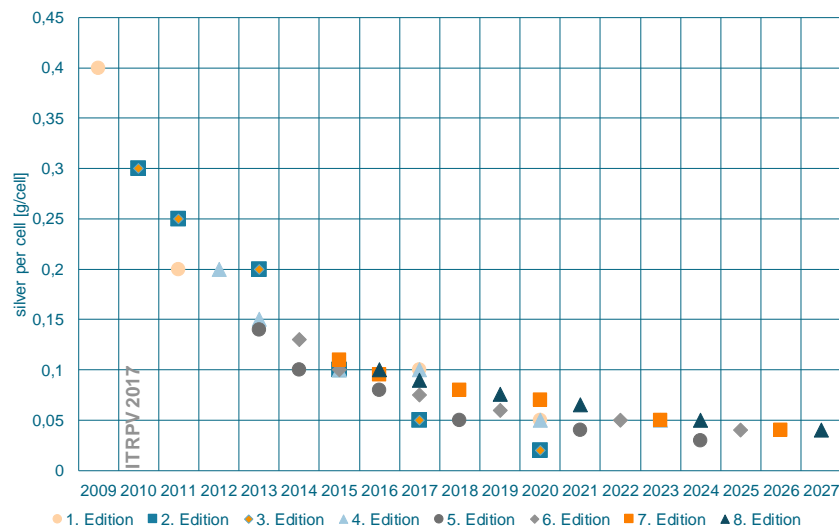


Parameters in main areas are discussed → Diagrams of median values

ITRPV 8th Edition 2017 – some statistics

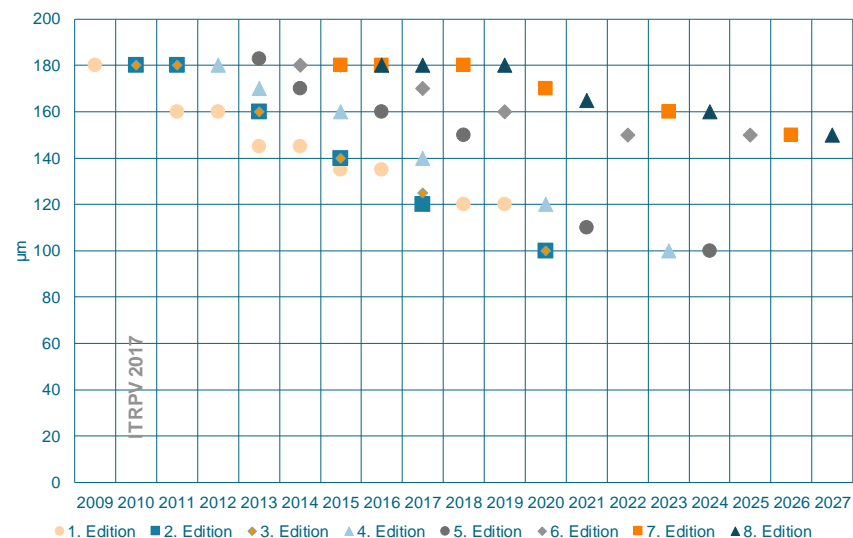


Silver amount per cell



Edition	8 th	7 th
Contributors	40	33
Figures	60	50

Wafer thickness (multi)



Prediction quality since 2009:

Silver consumption trend → well predicted and realized
(Silver availability depends on world market)

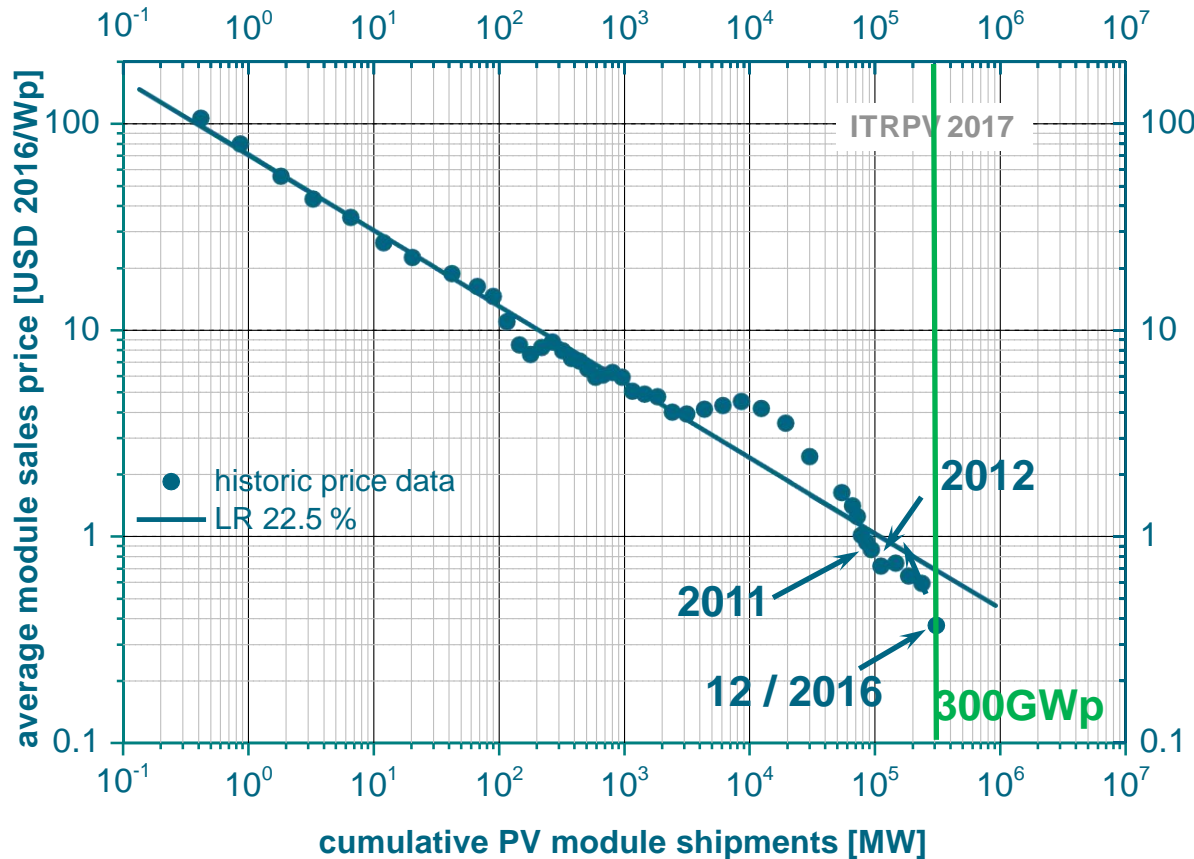
Wafer thickness trend → bad predicted and no progress
(Poly-Si price depends on PV market development)

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PV learning Curve



Shipments /avg. price at years end:



2016: 75 GWp / 0.37 US\$/Wp

o/a shipment: ≈ 308 GWp

o/a installation: ≈ 300 GWp

300 GWp landmark was passed!

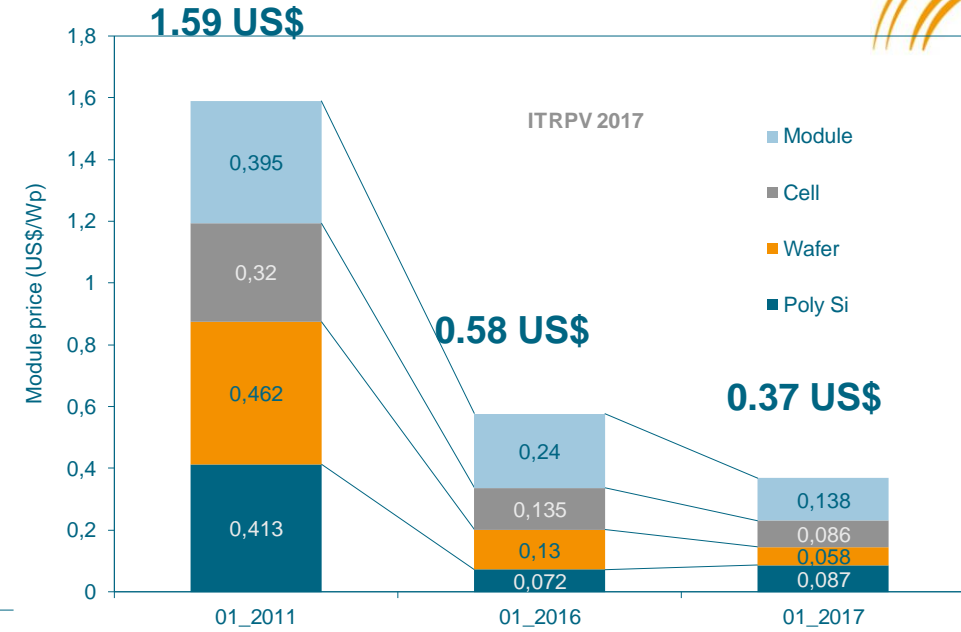
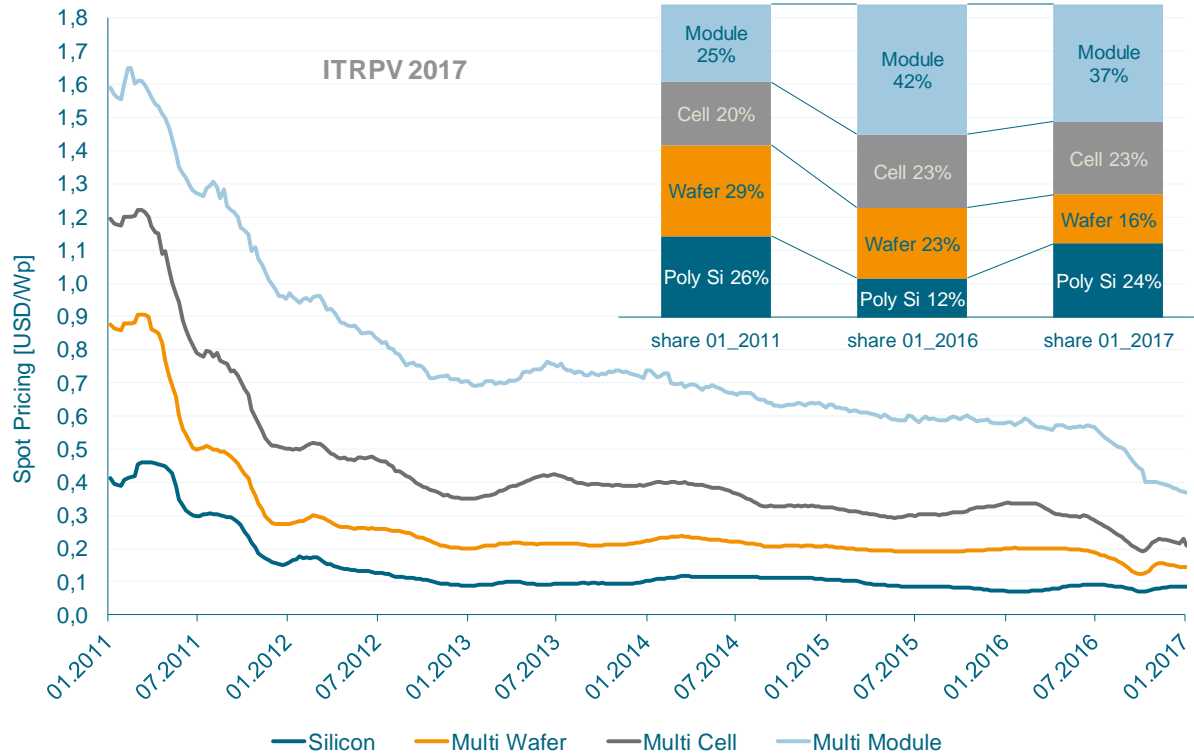
LR 21.5% (1976 2016)

dramatic price drop due to market situation

→ Comparable to 2011/2012, but faster

Module price break down [US\$/Wp]

Price considerations



- reduction 01/2011 → 01/2016: ≈ 64 %
- reduction 01/2016 → 01/2017: ≈ 36 %
- (reduction 01/2011 → 01/2012: ≈ 40 %)

Dramatic price drop during 2nd half of 2016

- Market driven drop
- Poly-Si share increased again
- High pressure on module manufacturers

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Silicon – Materials: Poly Si Feedstock Technology



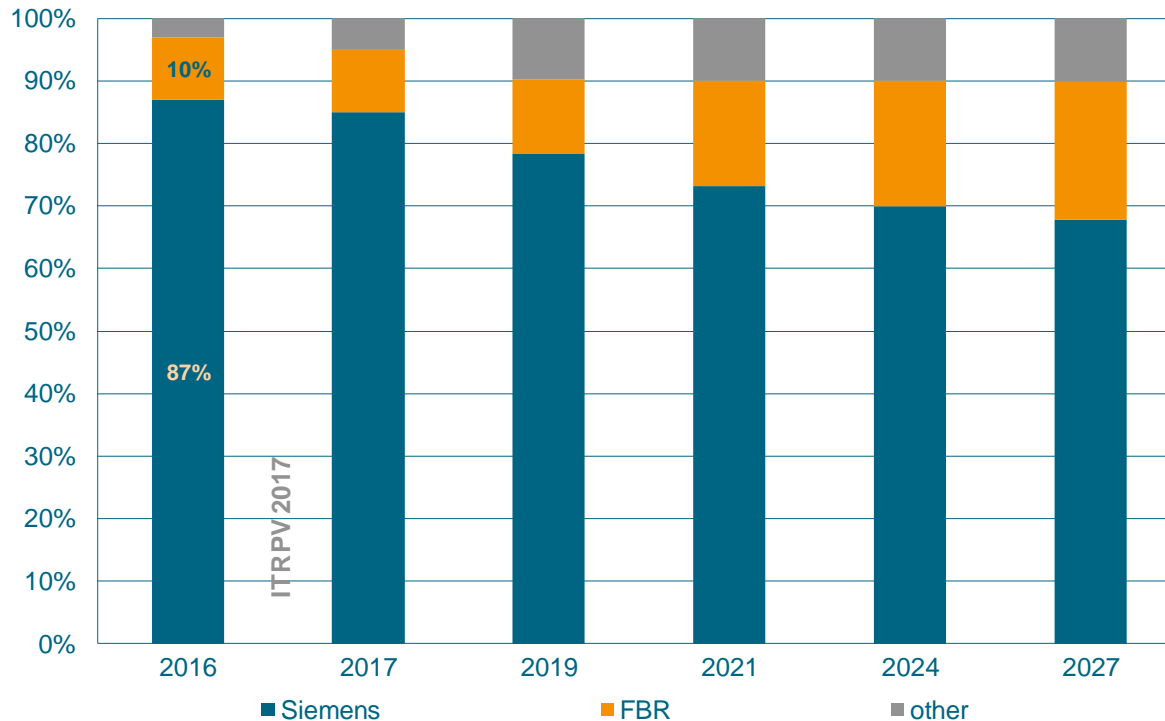
Trend: Share of poly-Si feedstock technology

Poly Si price trend:
 E 2012: 20 US\$/kg
 O2/ 2016: ≈14 US\$/kg
 O2/ 2017: ≈16 US\$/kg



Silicon feedstock technology

World market share [%]

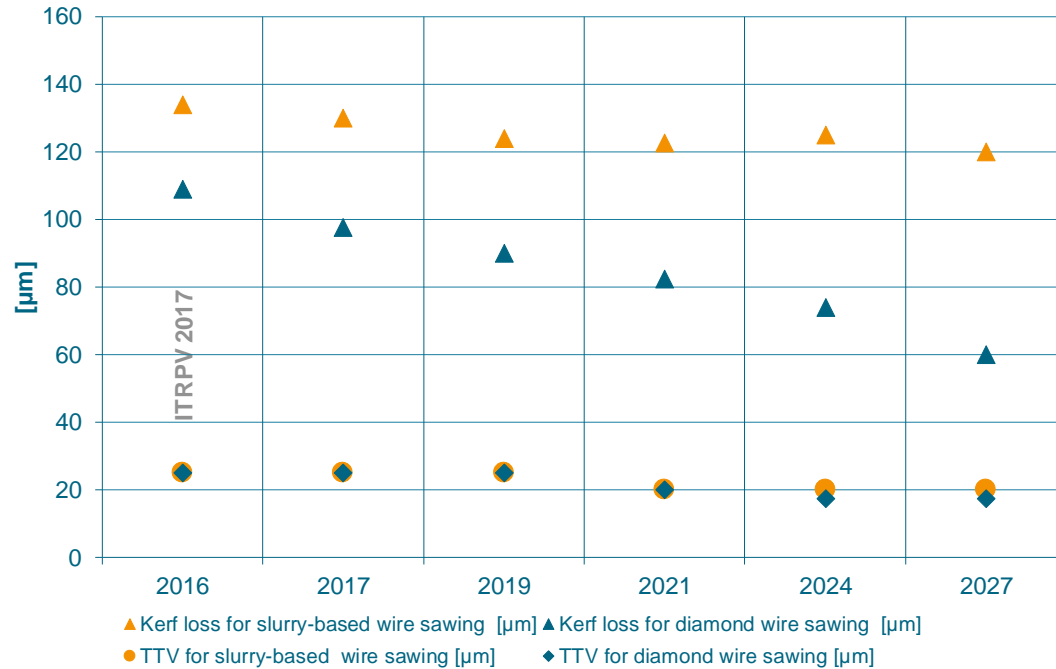


- oversupply situation of 2016 relieved
- Siemens process will remain mainstream
FBR shows potential for cost reduction
- **FBR share will be increased moderately w/ new capacity**
(2016 values in line w/ IHS Markit)

Other technologies (umg, epi growth, ..)
 → Not yet mature but available

Wafer – Processes: wafering technology (1)

Trend: Kerf loss / TTV



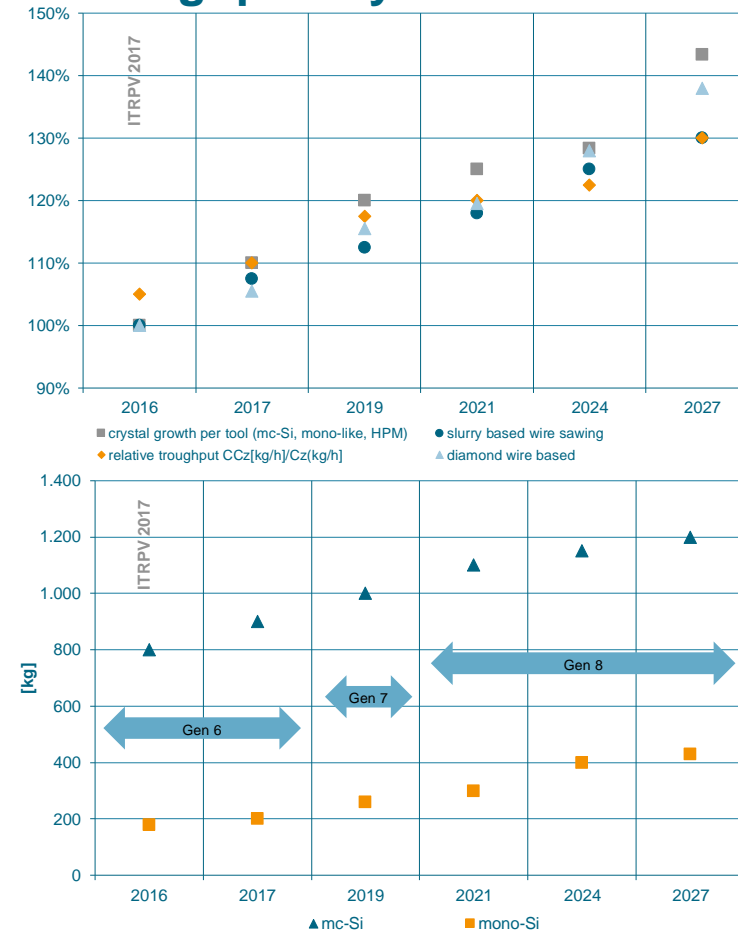
diamond wire sawing advantage:

→ enable faster kerf reduction

No big change in thickness variation is expected

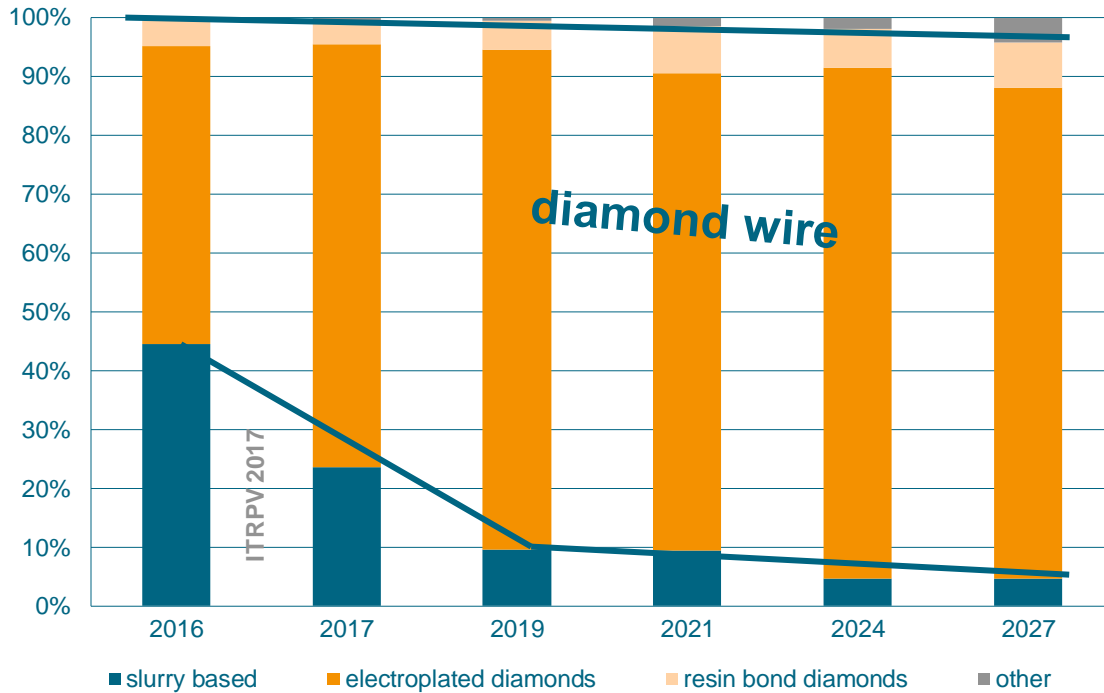
→ Throughput increase in crystallization/wafering will continue

Trend: throughput crystallization/ wafering



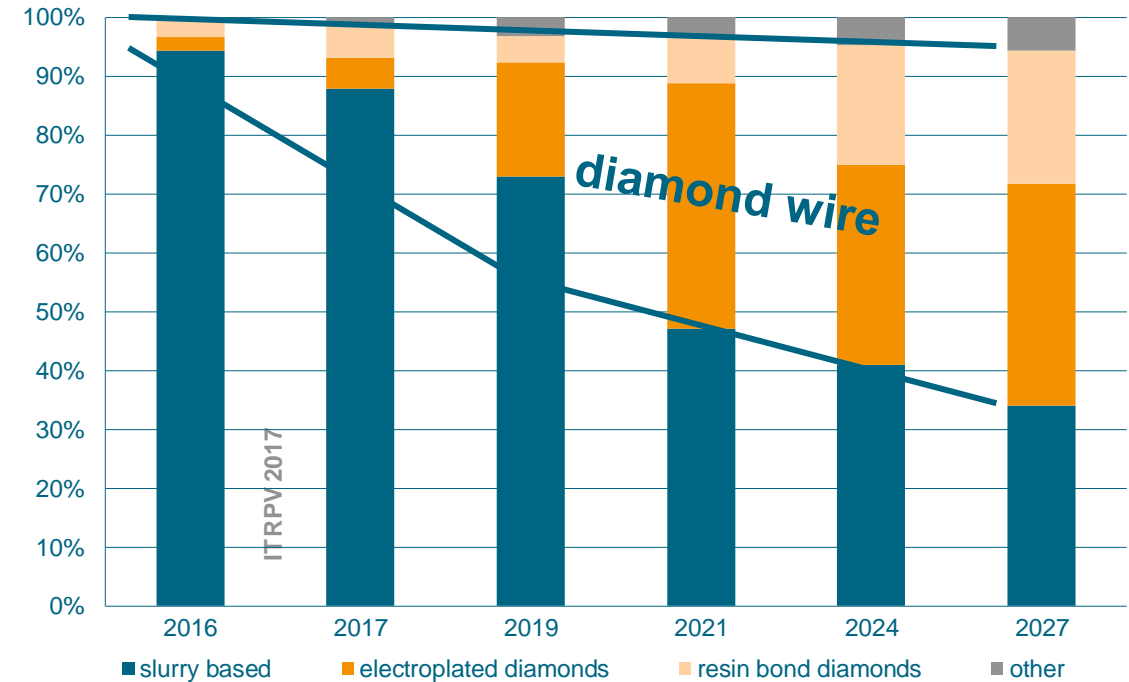
Wafer – Processes: wafering technology (2)

For mono-Si



diamond wire wafering now mainstream for mono-Si
 → Throughput 2x – 3x faster than slurry based

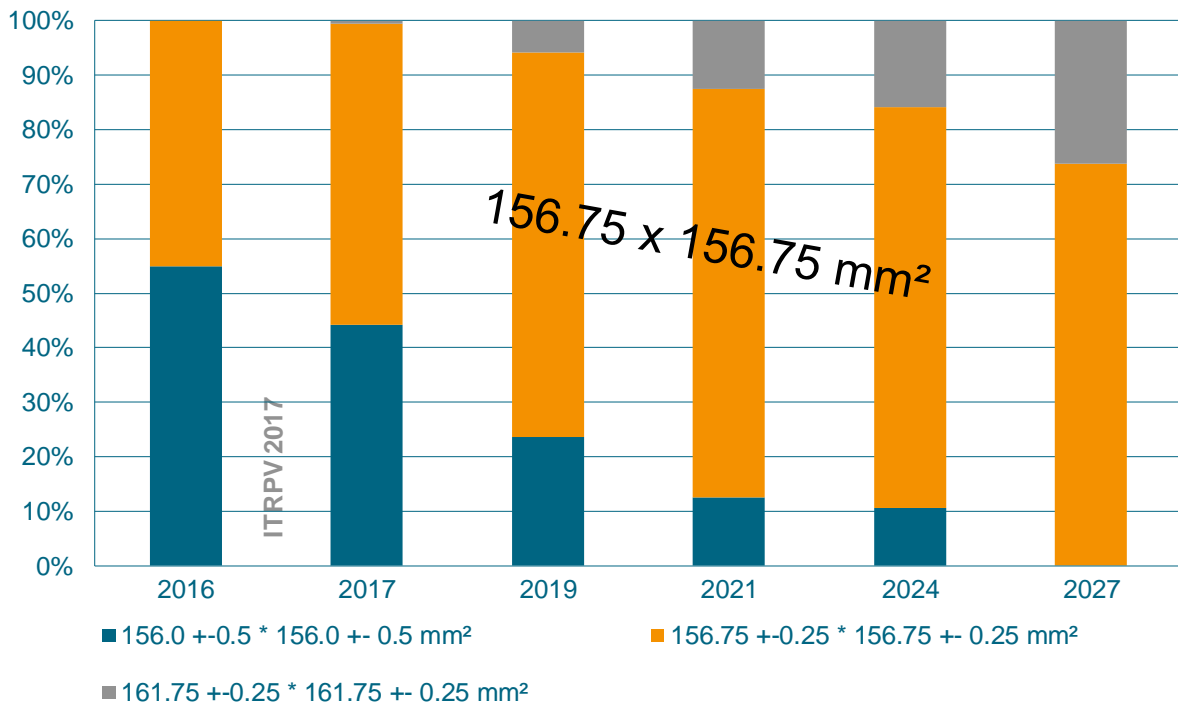
For mc-Si



For mc-Si change to diamond wire is ongoing
 → **main challenge: texturing**

Wafer – market share of wafer dimensions (new)

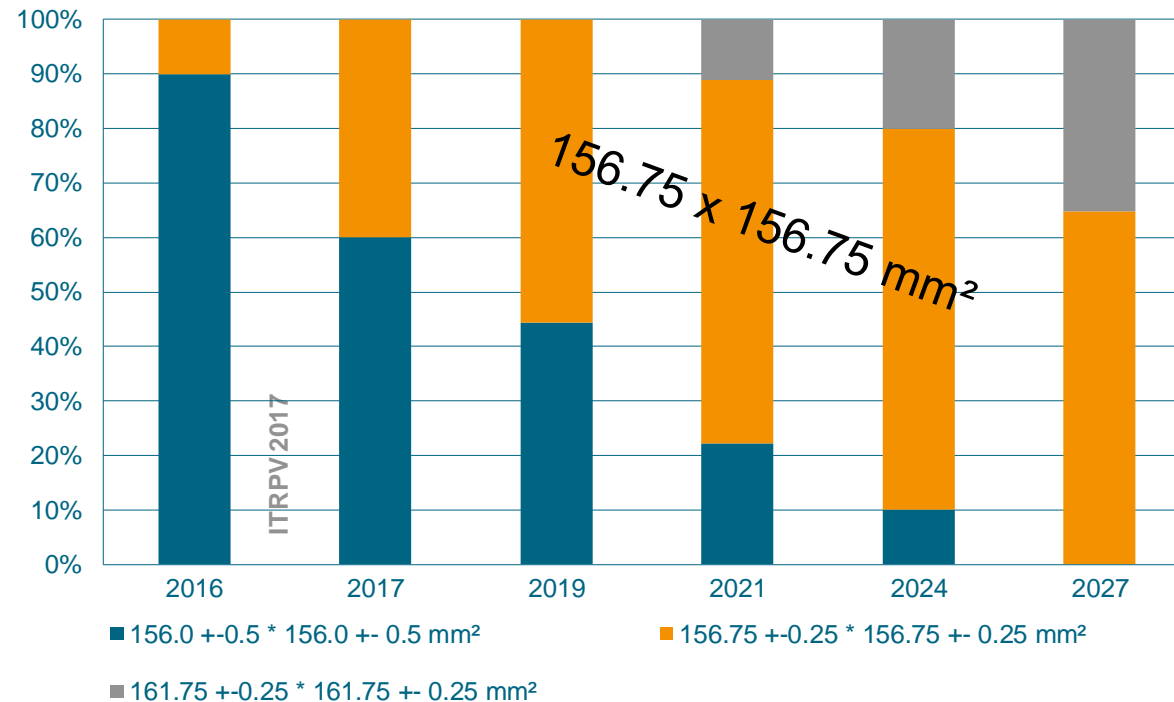
Trend: mono-Si



Fast switch to new format:

- New mainstream: 156.75 x 156.75 mm²
- Larger formats are upcoming

Trend: mc-Si

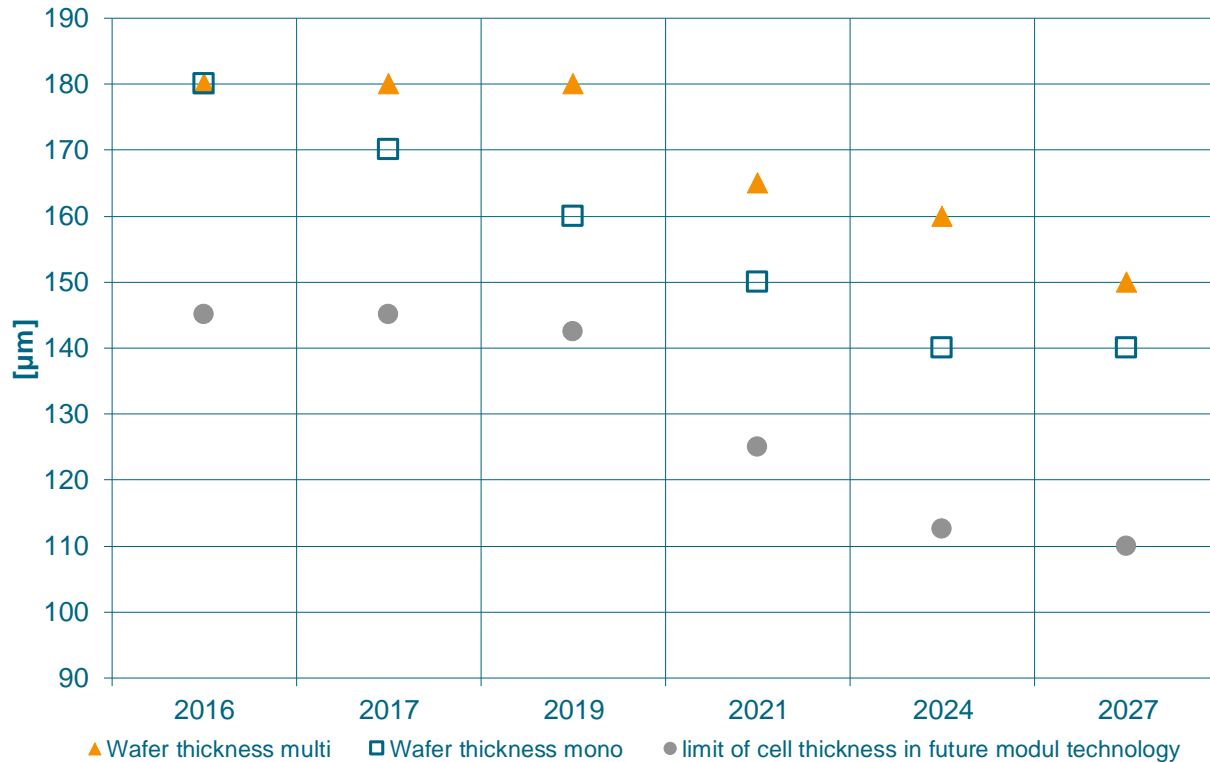


Transition to new format in 2017

- Expected new mainstream: 156.75 x 156.75 mm²
- Larger formats may occur after 2020

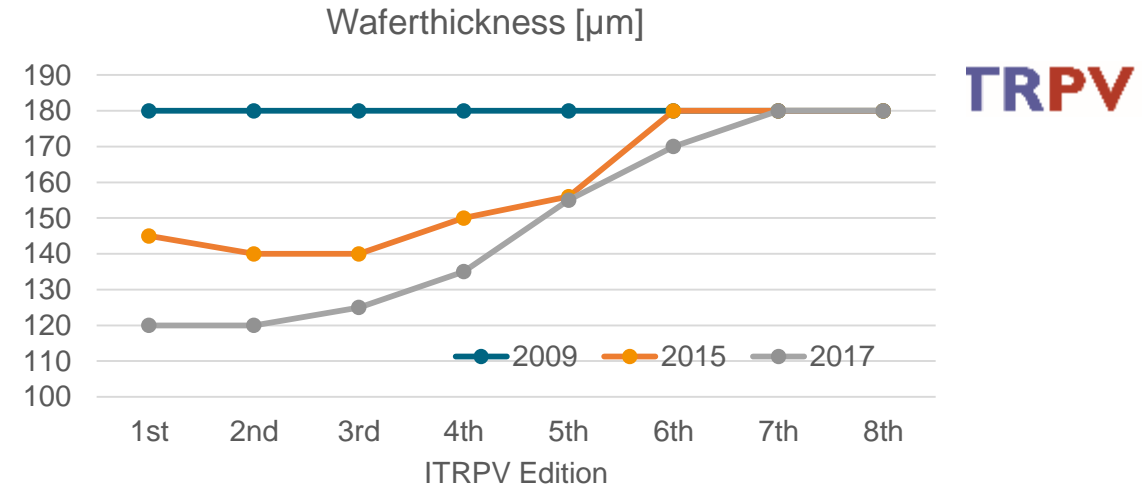
Wafer – Product: thickness trend

Trend: wafer thickness for mc-Si and mon Si wafers



Mono wafer: thickness reduction starts

- Still no progress in mc-Si thickness reduction



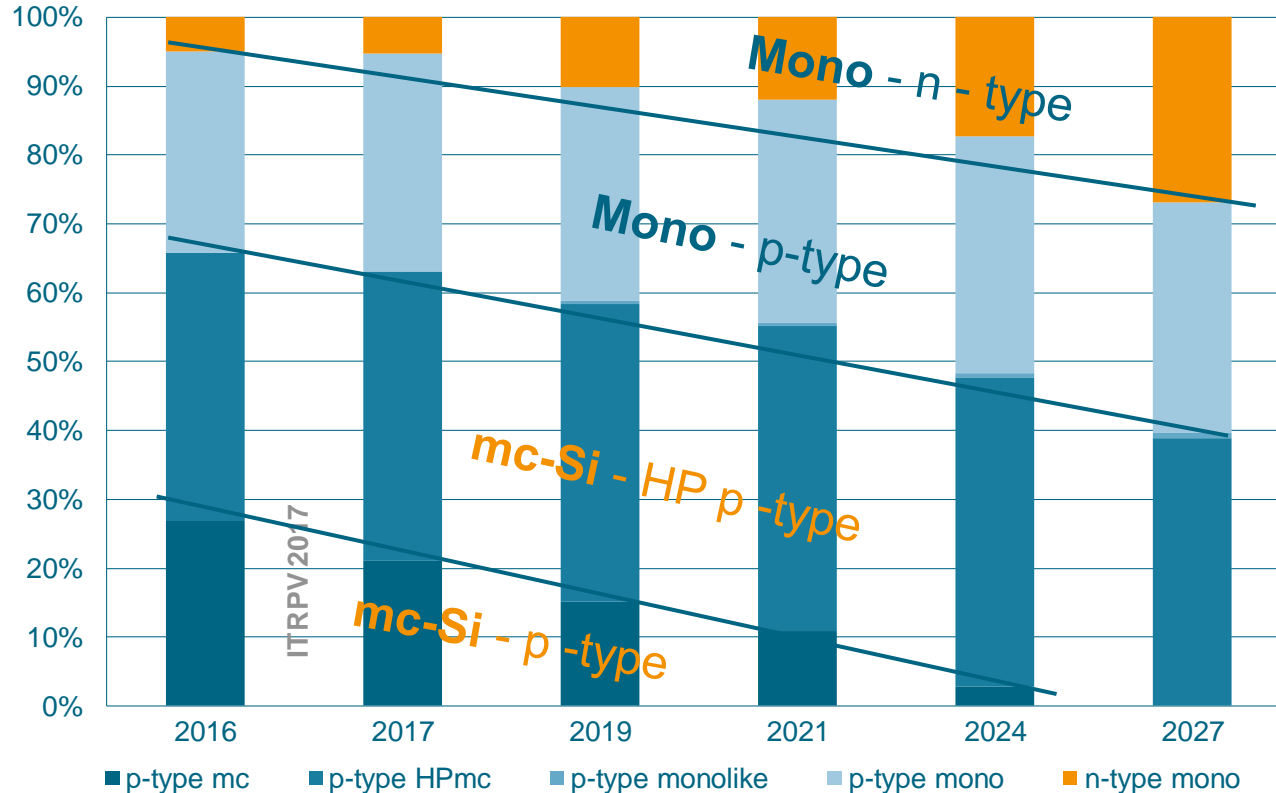
→ 180µm = preferred thickness since 2009

- Thickness reduction is expected to start for Mono
 - cost reduction potential
 - diamond wire will support

New module technologies enable further thickness reduction

Wafer – Product: market share of material types

Trend: share of c-Si material types



casted-Si domination is not for ever:
 → Trend of last years will continue

- **Casting technology:**
 → HP mc-Si will replace standard mc-Si
 → no “come back” of mono-like expected

- **Mono technology:**
 → n-type material share will increase
 → n- + p-type market share today ≈35%
 (2016 values are in line w/ IHS Markit)

- **p-type material is expected to stay dominant**
 → mainly due to progress in stabilization

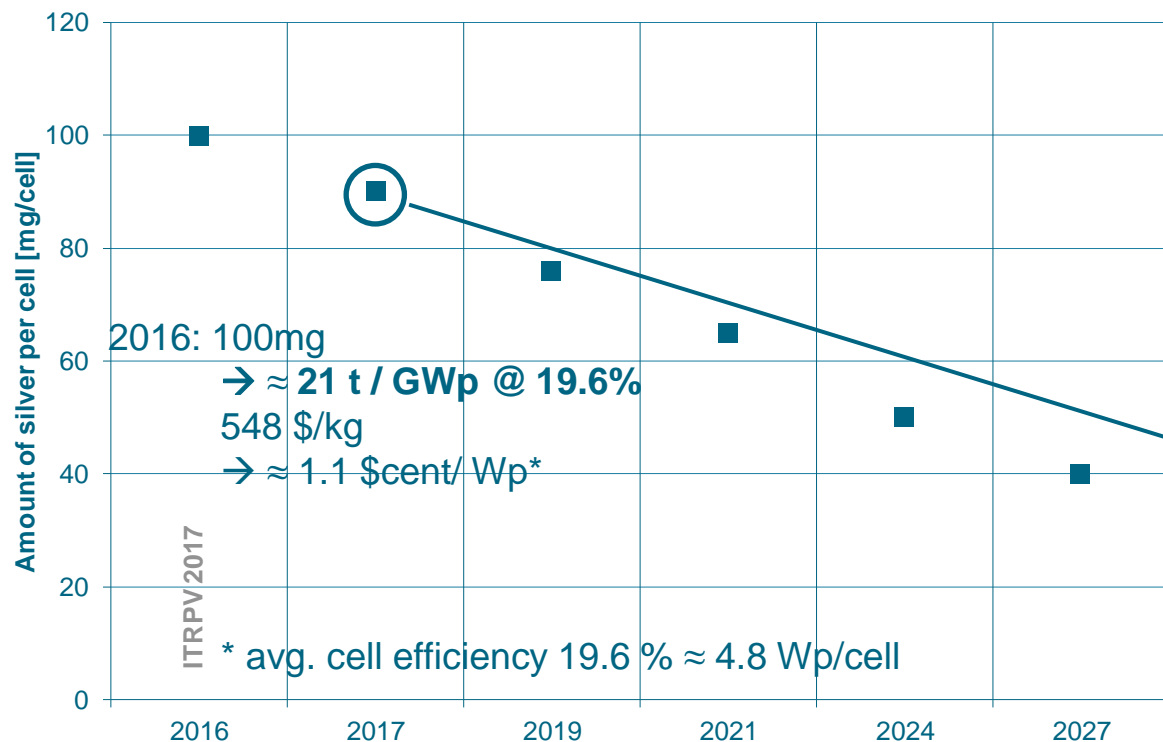
→ **Casted material is still dominating today with >60%**
 → **Mono share is expected to increase (driven by n-type)**

Outline

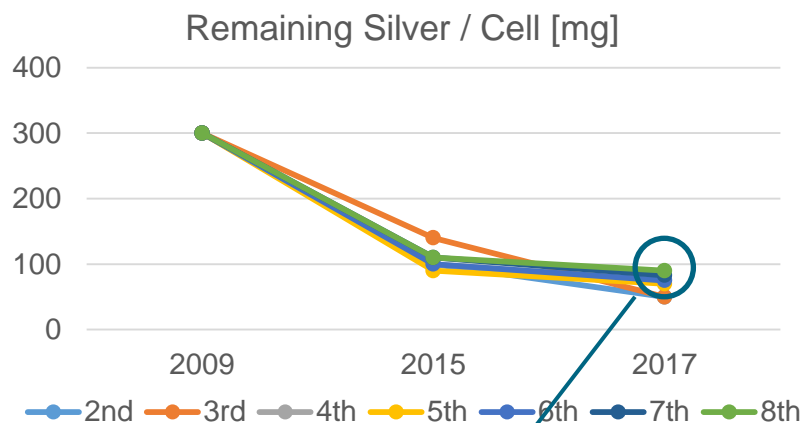


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Cell – Materials: Silver (Ag) per cell



Good prediction of Ag reduction continues



2009 300 mg
 2016 100 mg reached
 2017 90 mg expected
 → Ag accounts in 2016 for ≈ 8% of cell conversion cost

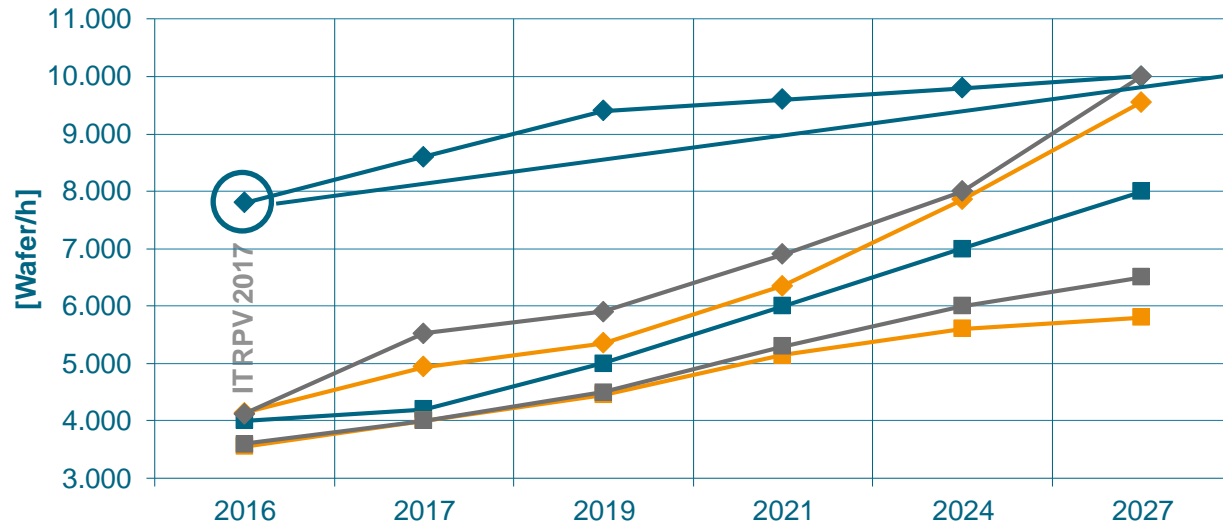
- Ag reduction is mandatory and continues
- delays substitution by Cu or other material

Ag will stay main metallization in c-Si technology

No break through for lead free pastes so far
 → Market introduction depends on performance

Cell – Processes: cell production tool throughputs

Trend: tool throughput increase + synchronization of frontend/backend



Wet benches are leading today with > 7800 wf/h
 → Throughput increase continues

Challenge: increase throughput + Improve OEE

Two throughput scenarios:

Progressive = new high throughput tools

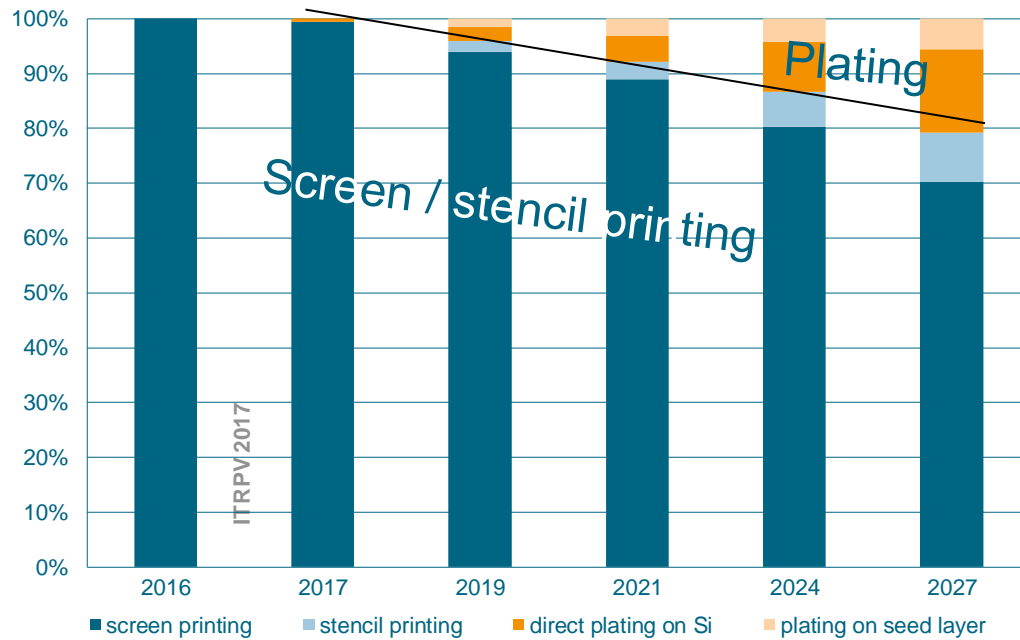
Evolutionary = continuous improvement of existing tools (debottlenecking, upgrades...)

Cell – processes: c-Si metallization technologies



Front side metallization technologies

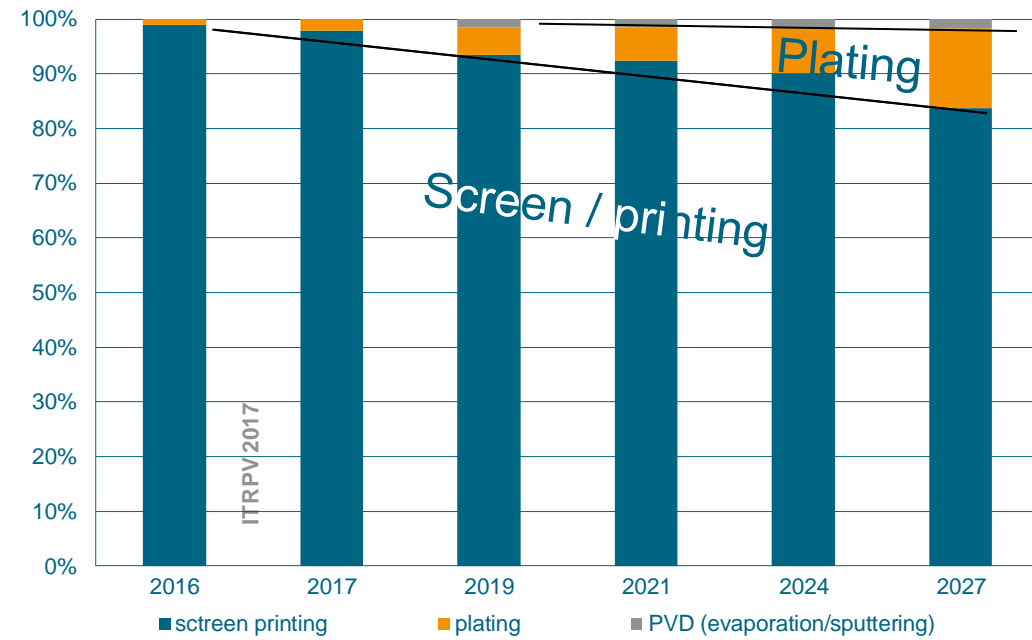
World market share [%]



Rear side metallization technologies



World market share [%]

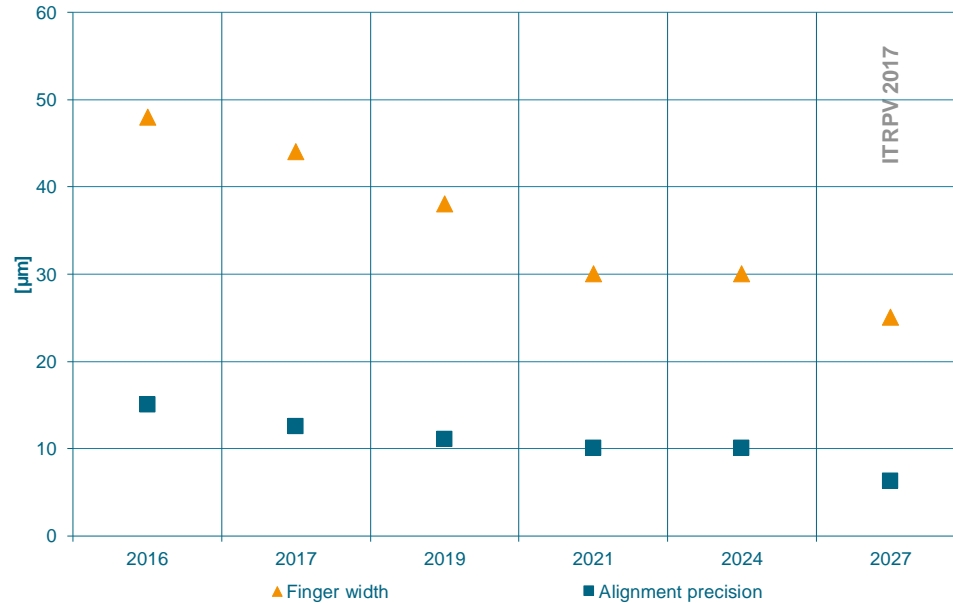


Screen printing remains main stream metallization technology

- Plating is expected for rear and front side
- For rear side PVD methods may appear

Cell – processes: finger width / number of bus bars / bifaciality

Trend: Finger width / alignment precision



Front side grid finger width reduction continues

2016: < 50µm reached!

→ Enables Ag reduction, requires **increase of number of busbars**

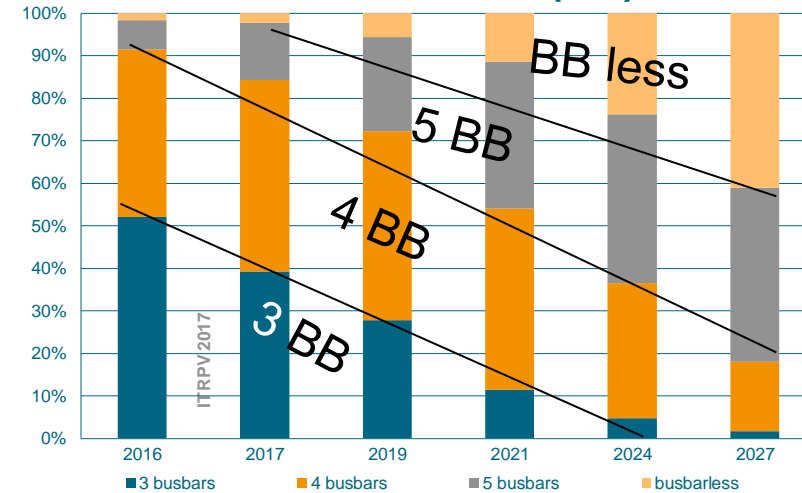
→ **4BB are mainstream** – 3 BB will disappear

Alignment precision will improve to <10µm @3 sig.

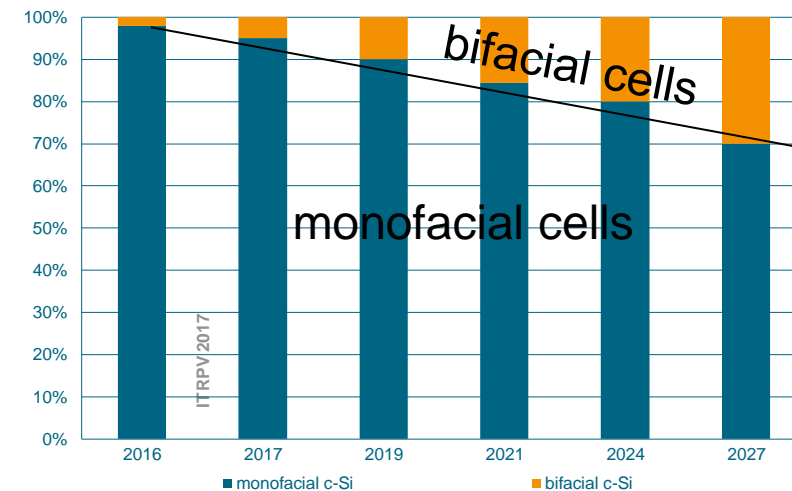
→ Selective emitters + Bifacial cells require good alignment

→ **Bifacial cells will increase market share**

Trend: number of bus bars (BB)

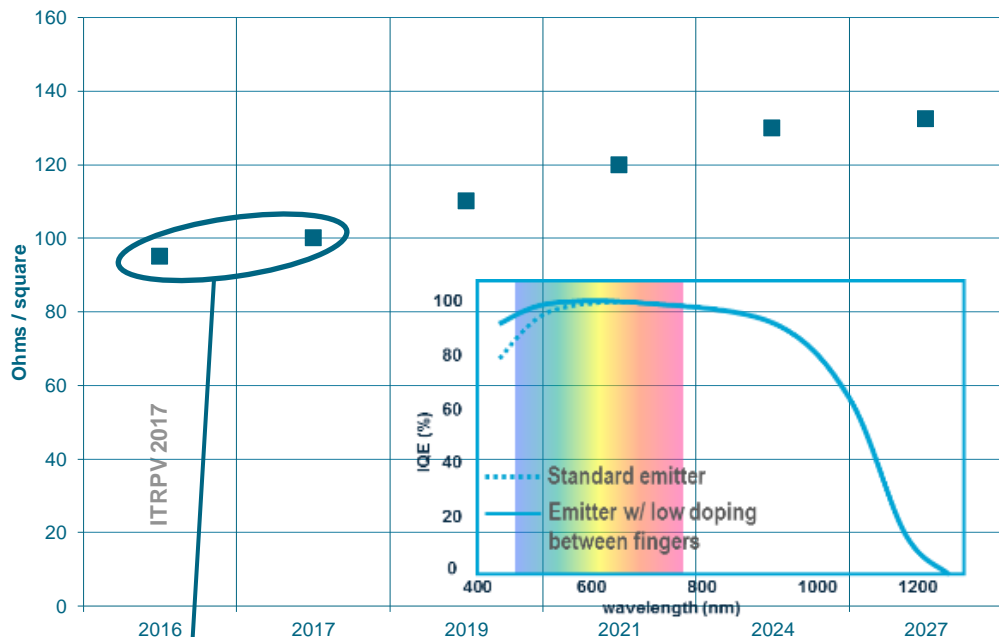


Trend: market share of bifacial cells



Cell – processes: emitter formation for low $J_{0\text{front}}$

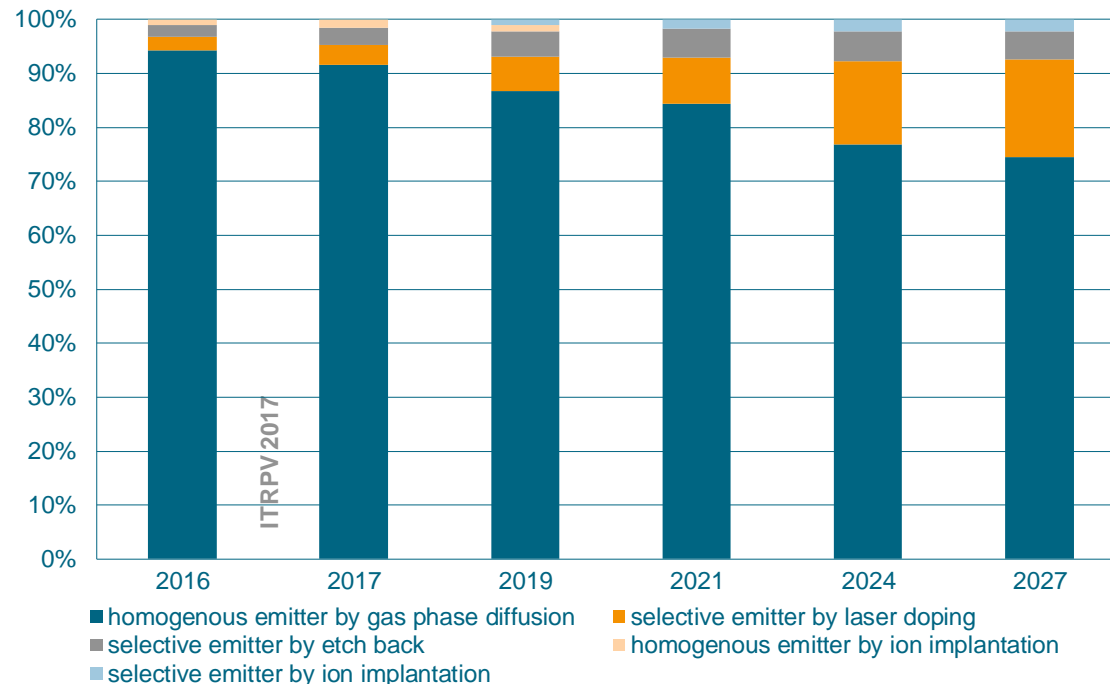
Trend: emitter sheet resistance



Essential parameter for $J_{0\text{front}}$

- 95...100 Ω/\square are standard today
- Increase to 135 Ω/\square is predicted
- Challenge for tools and front pastes

Trend: emitter formation technologies

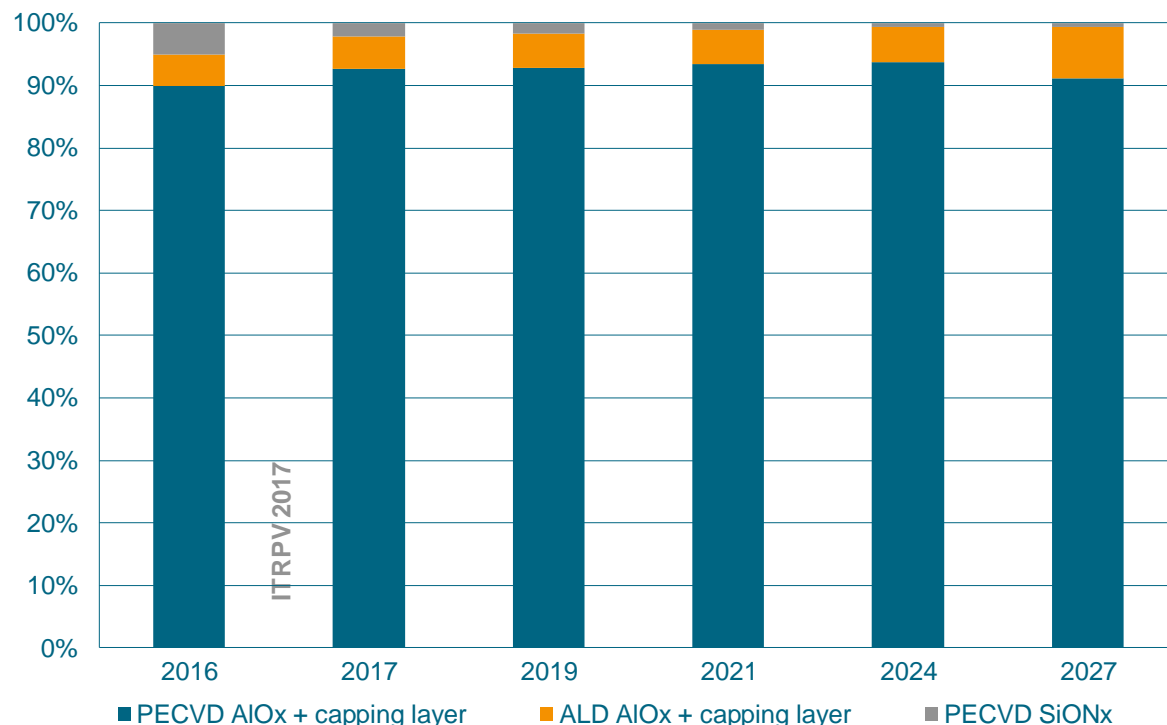


Mainstream: homogenous gas-phase diffusion

- selective doping: etch back or laser doping
- Ion implant stays niche

Cell – processes: technology for low $J_{0, rear}$

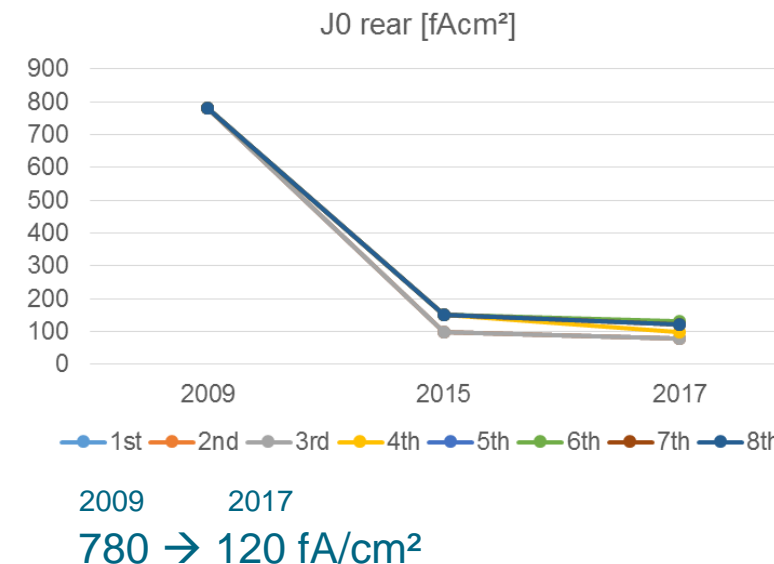
Trend: rear side passivation technologies



Rear side passivation is mandatory for PERC

- **PECVD AlOx will stay mainstream**
- ALD will hold up to 10 %
- SiONx will disappear

ITRPV prediction for $J_{0, rear}$ were good

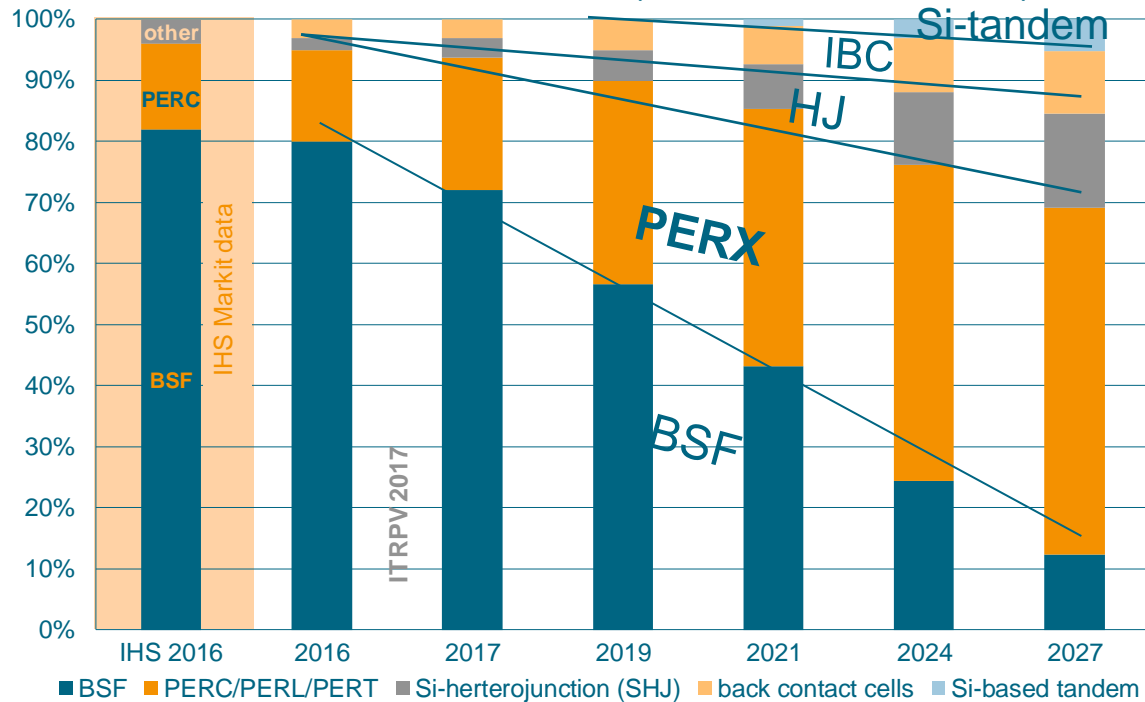


- BSF cannot deliver required low $J_{0, rear}$
- PERC takes over
- competing technologies in PERC
 - PECVD Al₂O₃ + capping
 - Al₂O₃ ALD + capping
 - PECVD SiONx/SiNy etc.

Cell – Products: cell technologies / cell efficiency trends

Trend: market share of cell concepts

2016: PERC ≈15% (in line w/ IHS Markit)



PERX is gaining market share (20% 2017)

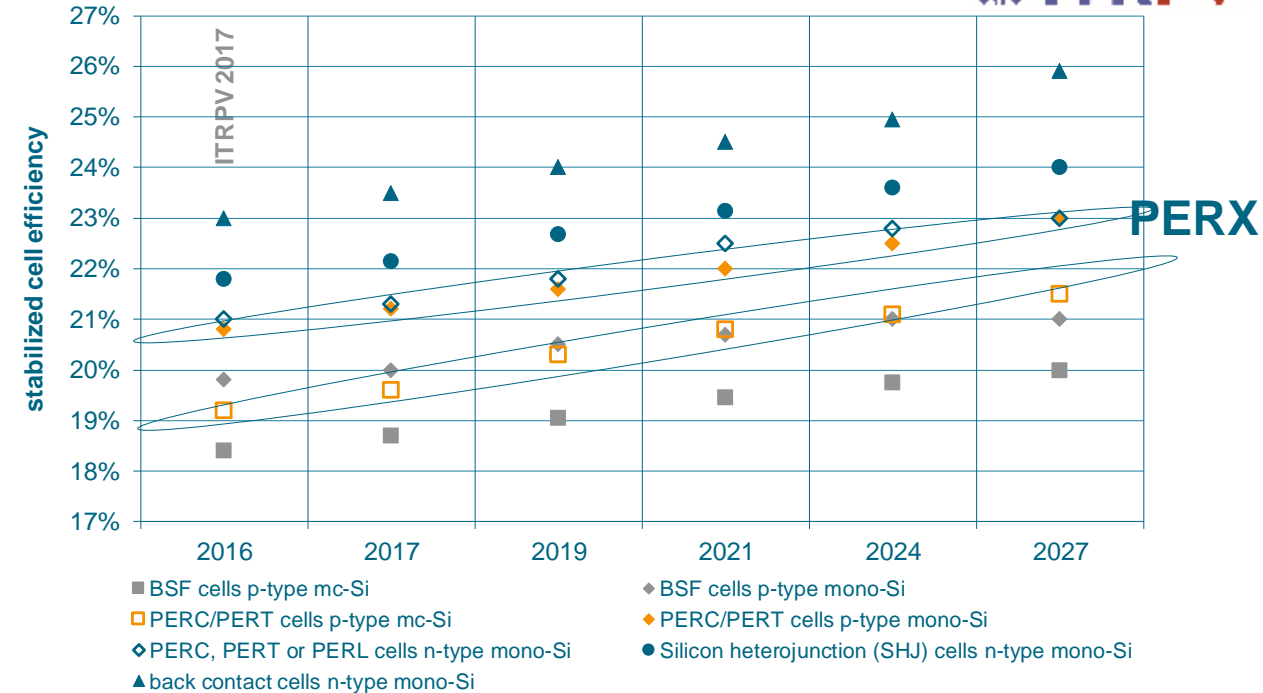
→ **BSF share is shrinking**

→ **Back contact + HJ: slow increasing share**

→ **Si tandem: under development**

Trend: stabilized cell efficiencies;

→ **p-type PERC outperforms**



p-type mono PERX will reach n-type performance

mc-Si PERX is about to outperform mono BSF

→ **n-type IBC + HJ for highest efficiency applications**

→ **stabilized >21% p-type mono PERC is in production**

Outline

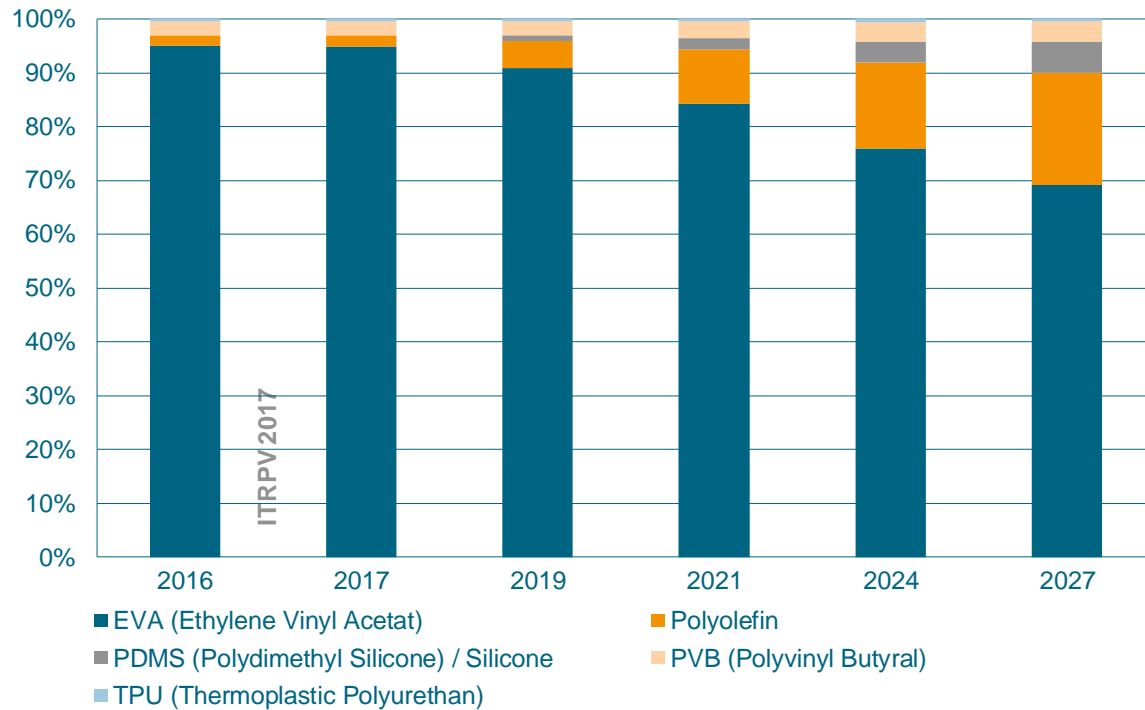


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Module – Materials: foils

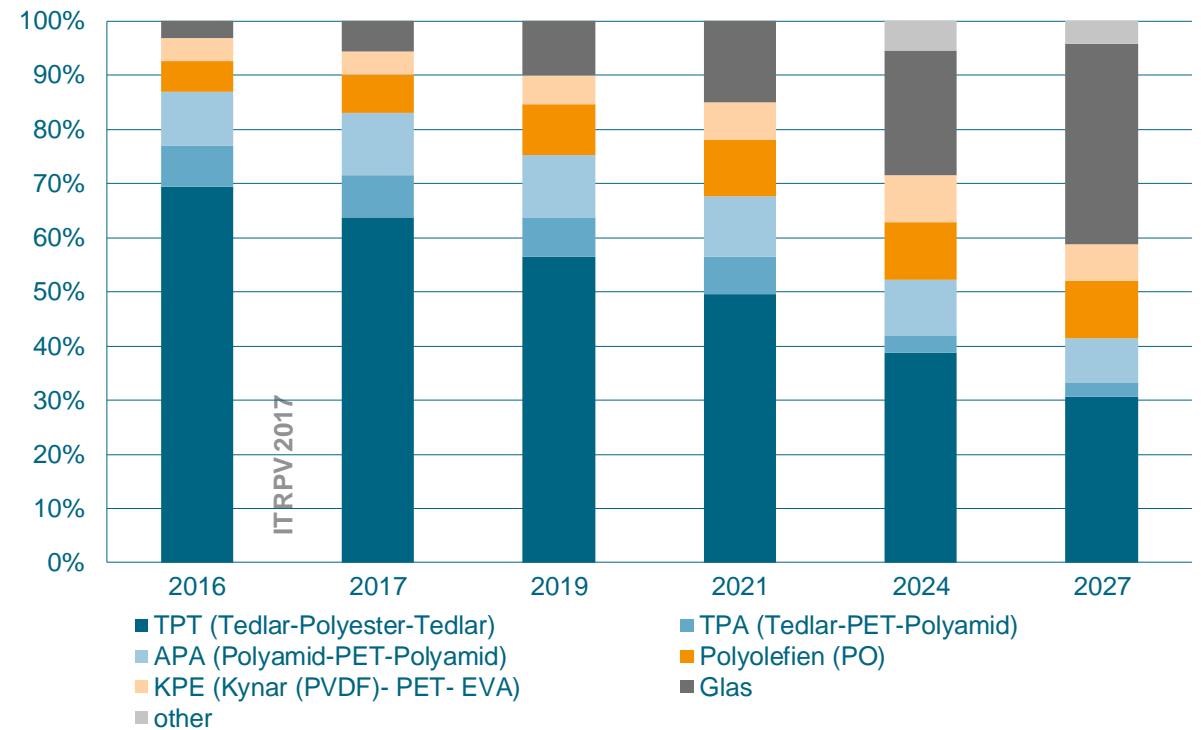


Trend: share of encapsulant materials



EVA is mainstream
Polyolefine will increase market share

Trend: share of back-sheet materials

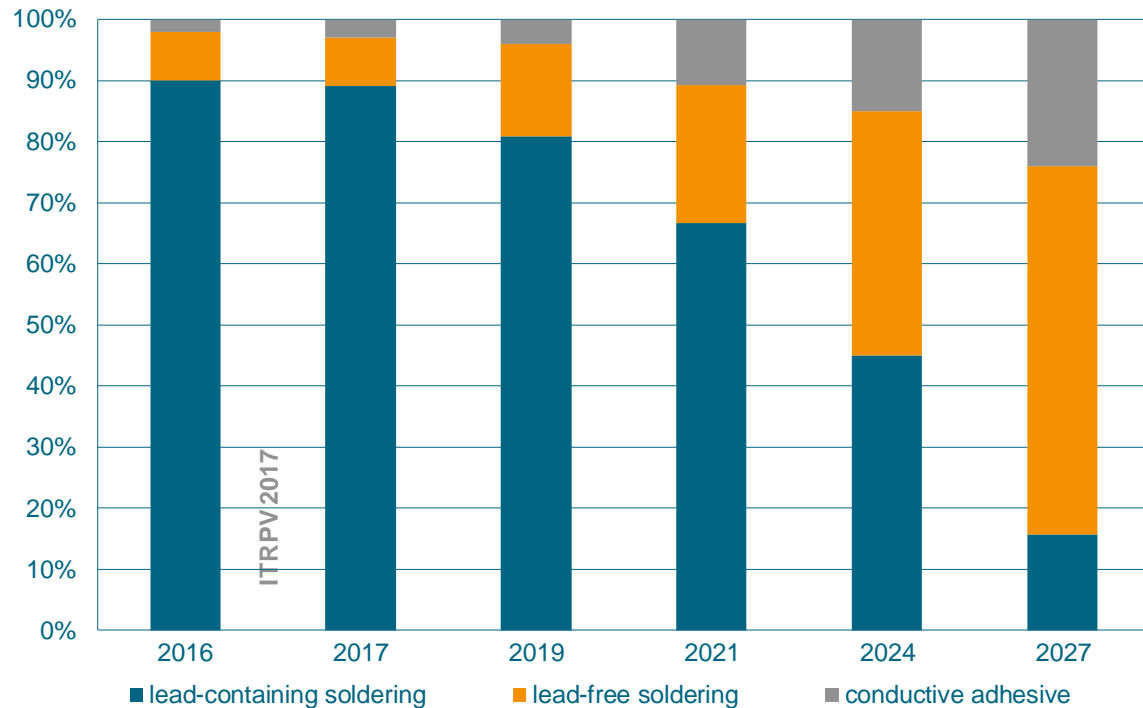


Glas will gain share as back cover material
TPT will lose share on the long run

Module – Processes: interconnection technology

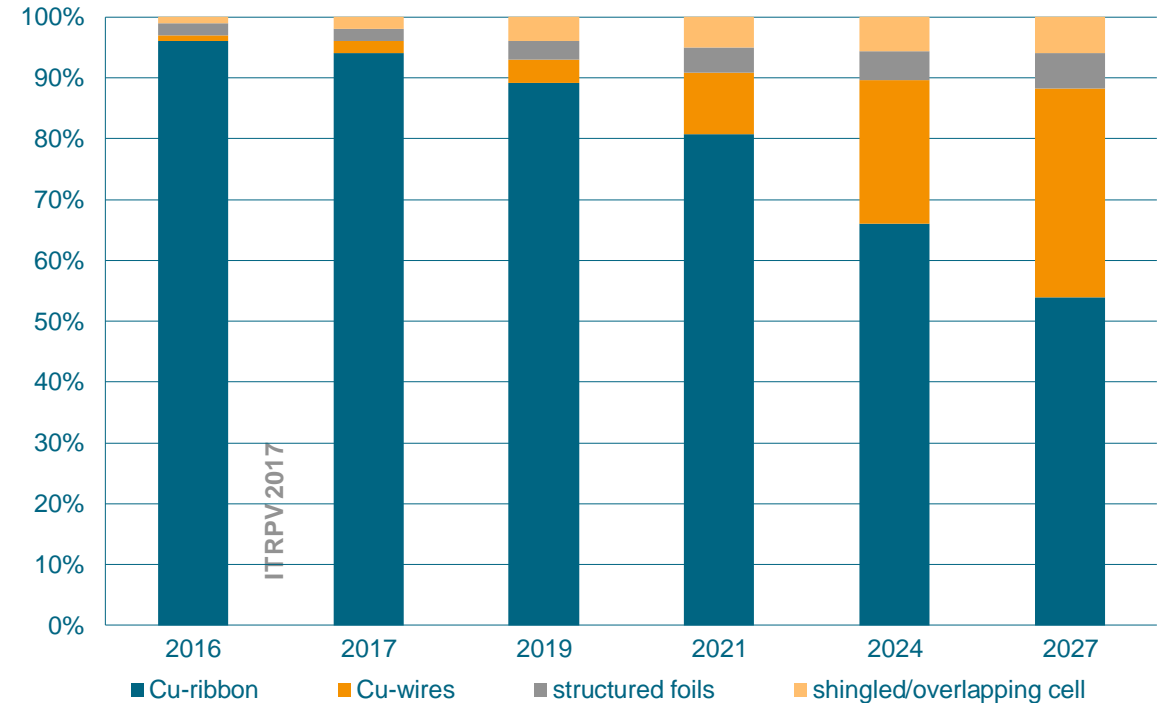


Trend: cell interconnection technology



Expanding market share:
lead free soldering + conductive adhesives

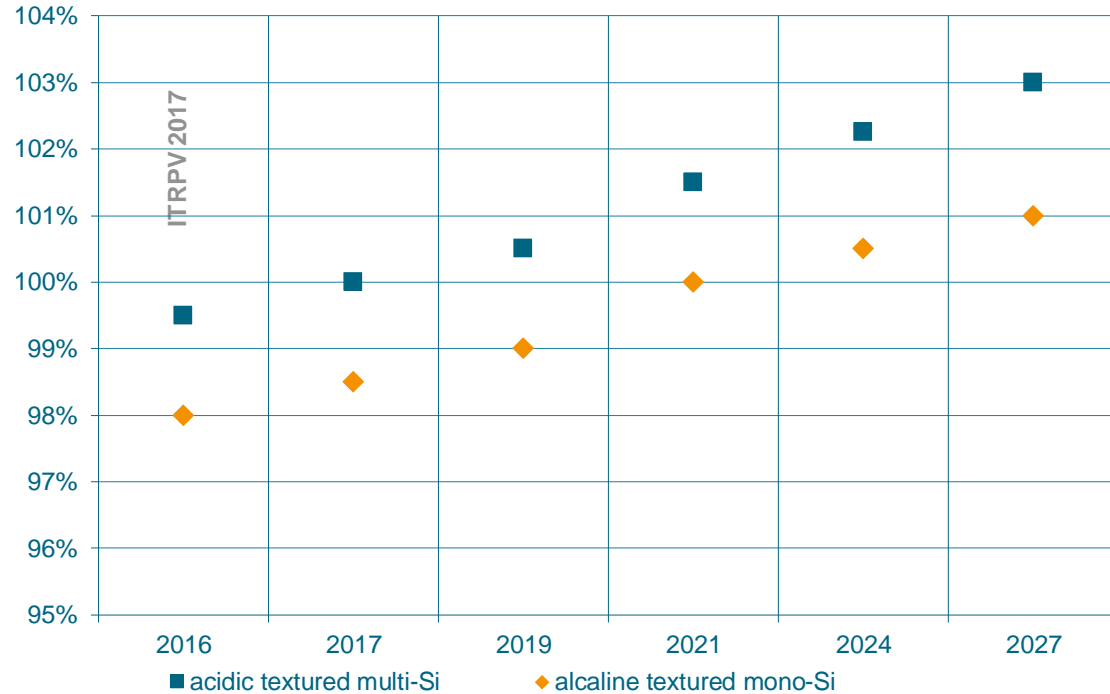
Trend: cell connection material



Cu will remain most widely used cell connection material
Cu wires will increase market share

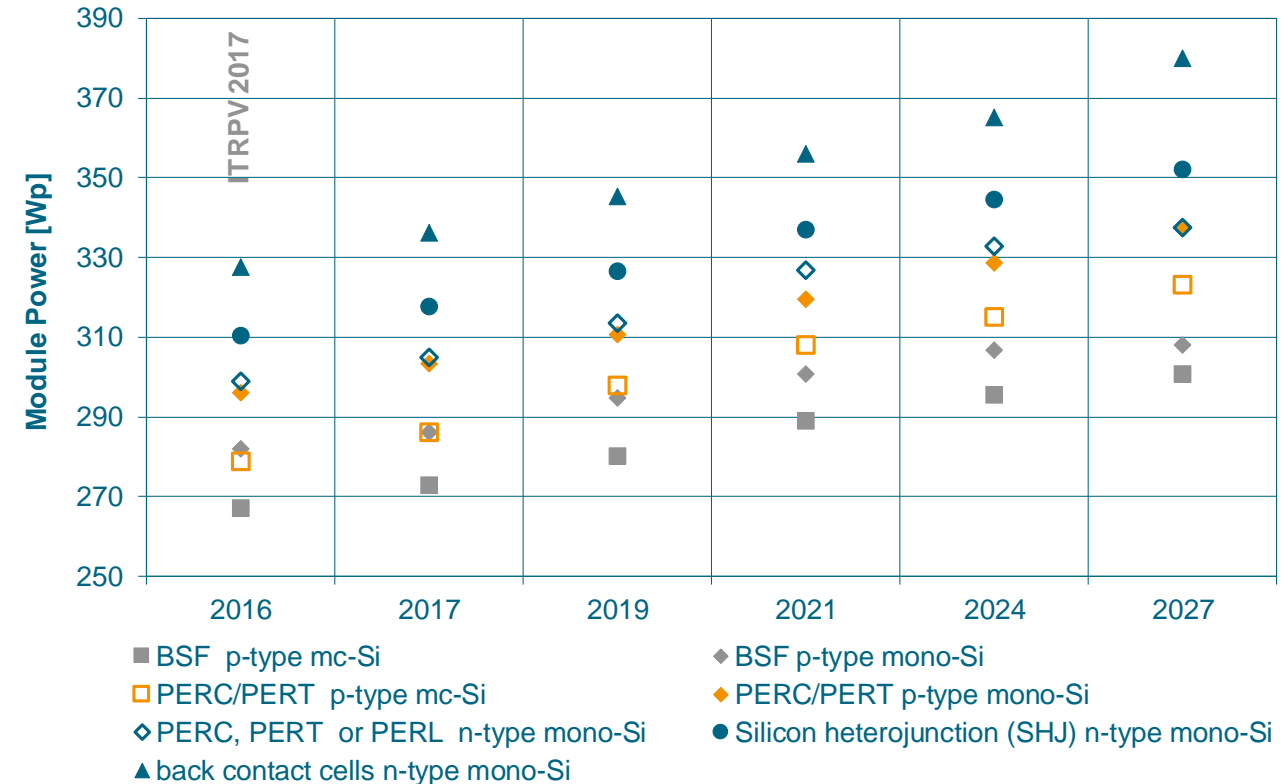
Module – Products: module power outlook

Trend: cell to module power ratio (CTM)



CTM will increase to > 100%
 → Acidic texturing has higher CTM

Trend: module power of 60 cell (156x156mm²)

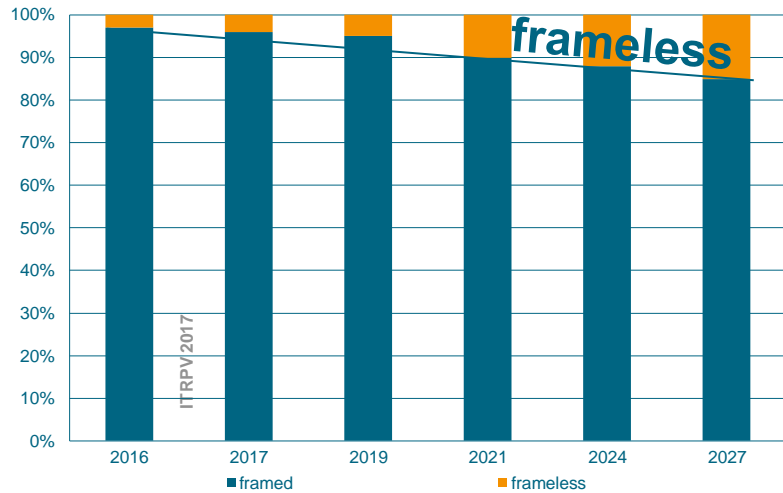


60 cell modules 2017:

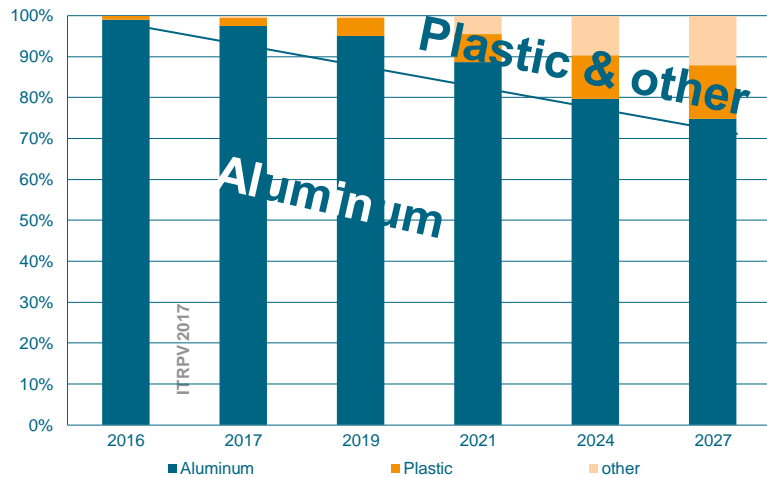
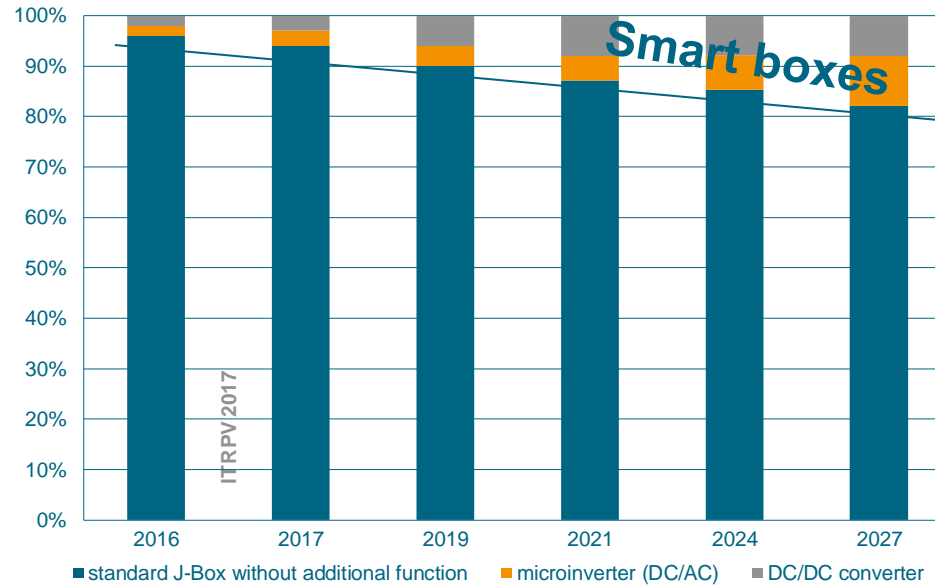
Mono p-type PERX: 300 W are standard
Multi p-type PERX: 285 W are common

Module – Products: framed modules and J-Boxes

Trend: share of frameless c-Si modules



Trend: share of smart J-Boxes



Al-frames will stay mainstream

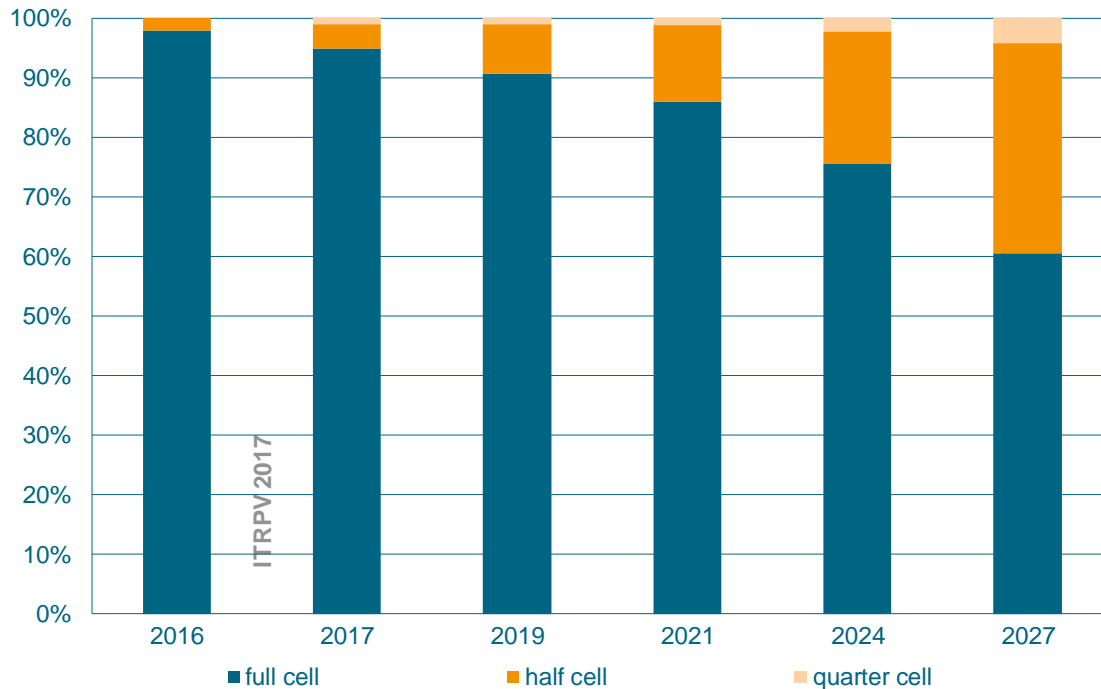
→ frameless for niche markets

Standard J-Box remains mainstream

Smart J-Boxes for niche applications

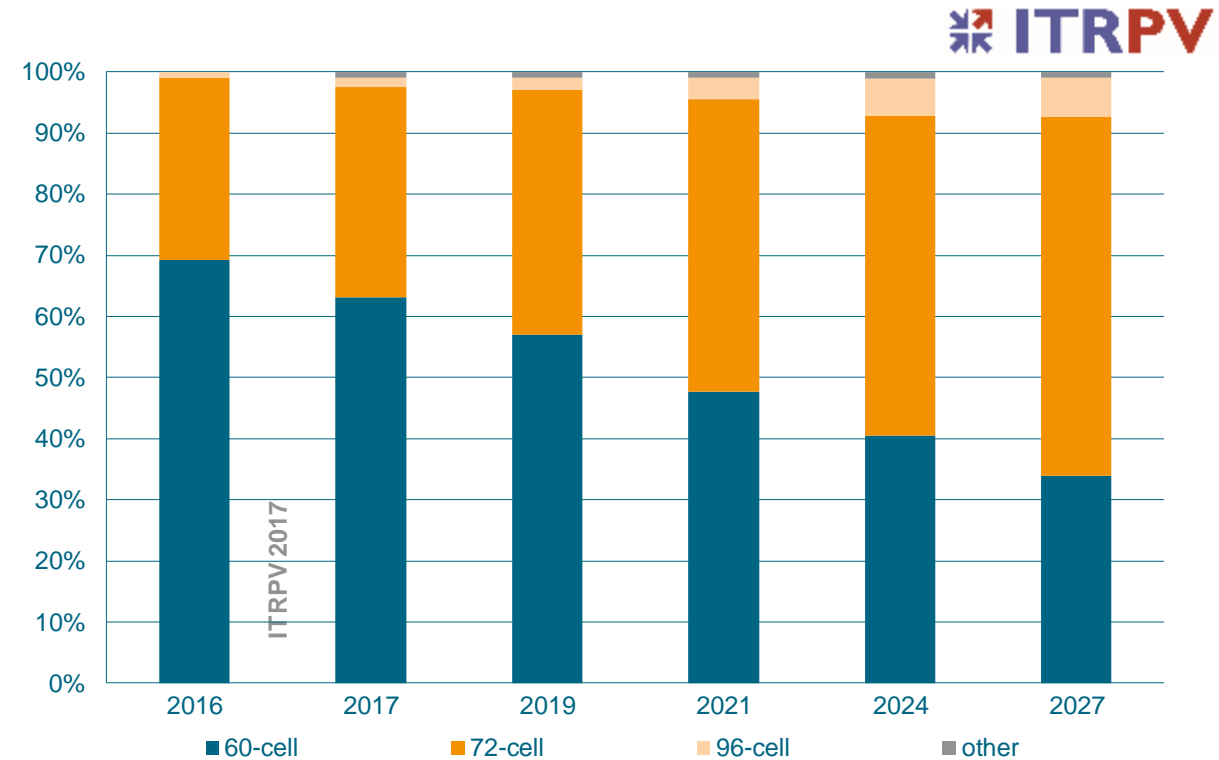
Module – Products: module size

Trend: share of cell dimensions



Full cell will remain main stream
half cell implementation started!
 quarter cells – currently a niche

Trend: share of module size (full cell)

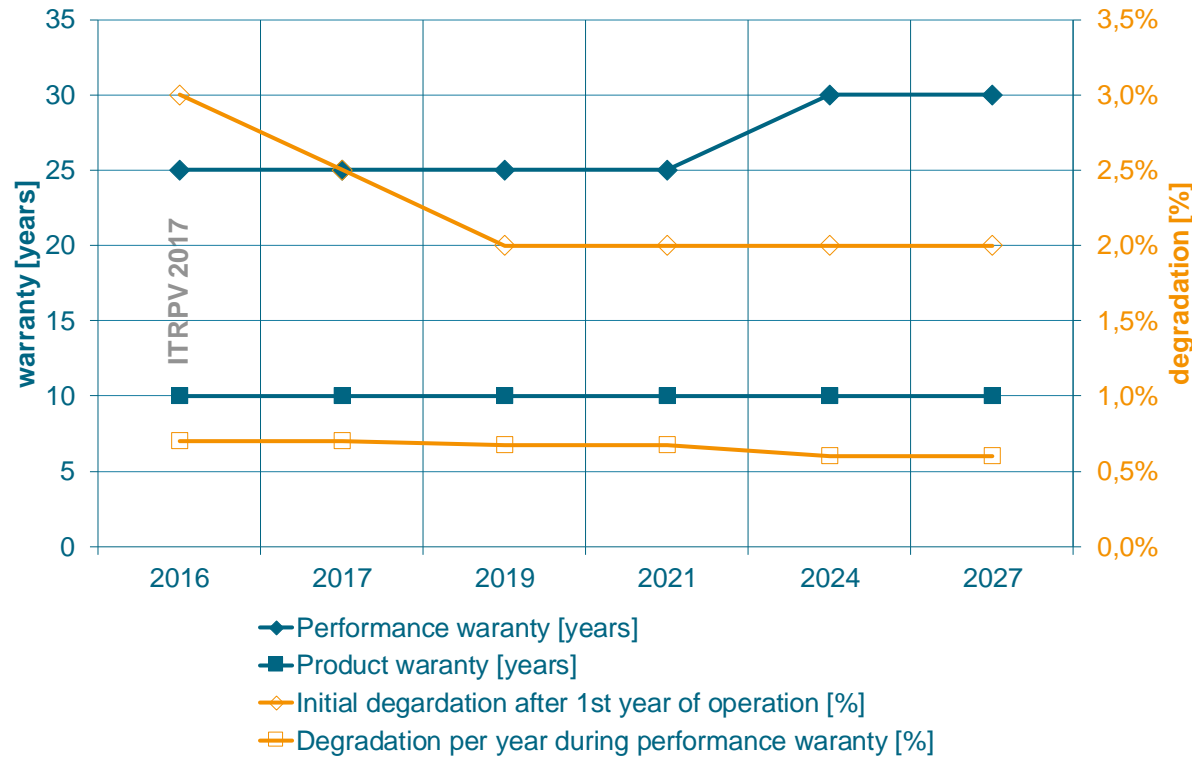


Big is beautiful: **72 cell module share will increase**
 60 cell modules → mainstream until 2020

Module – Products: module reliability (new)



Trend: warranty conditions and degradation for c-Si modules



Product warranty will remain 10 years
Performance warranty 2024+: 30 years

degradation:	Initial / linear/year
2016:	3.0 % / 0.7%
2017:	2.5 % / 0.68%
2019+:	2.0 % / 0.68%
2021+:	2.0 % / 0.60%

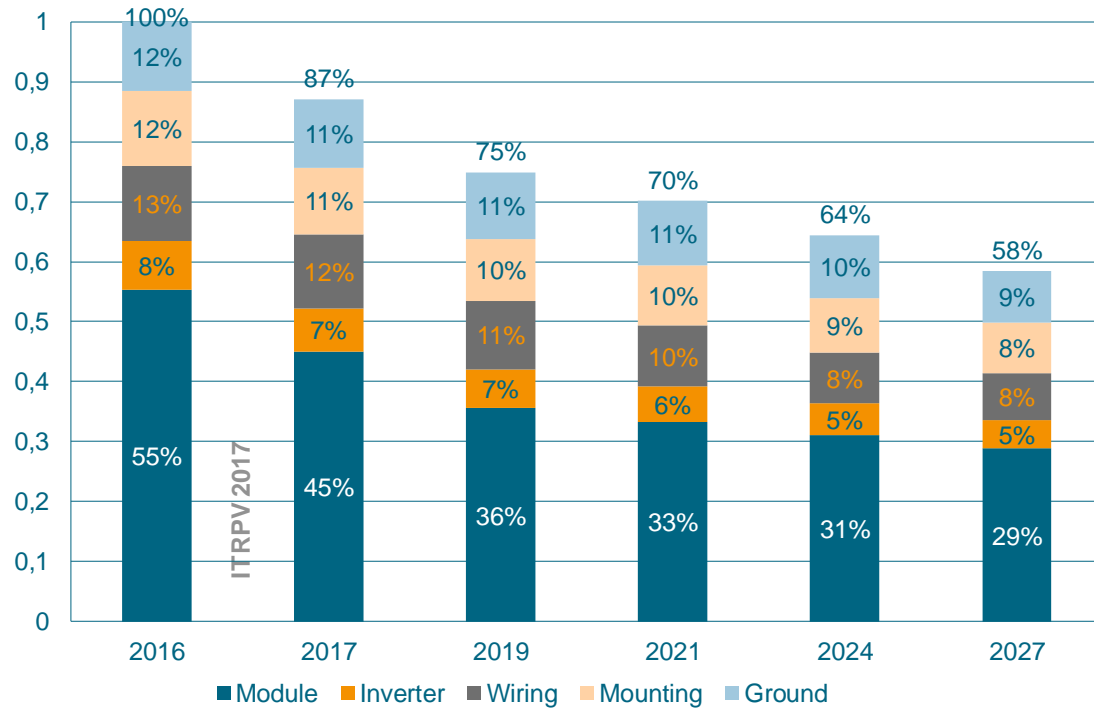
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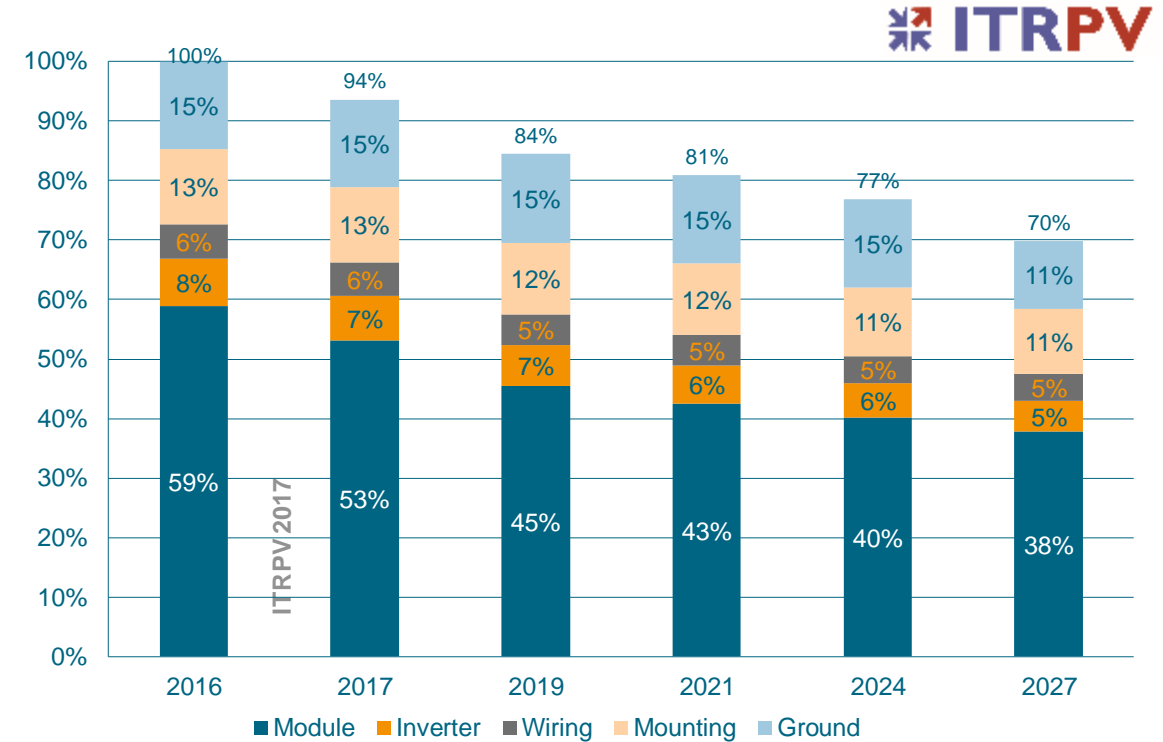
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Systems – Balance of system (BOS) for power plants

Trend: BOS in Europe and US



Trend: BOS in Asia



Still significant cost reductions foreseen

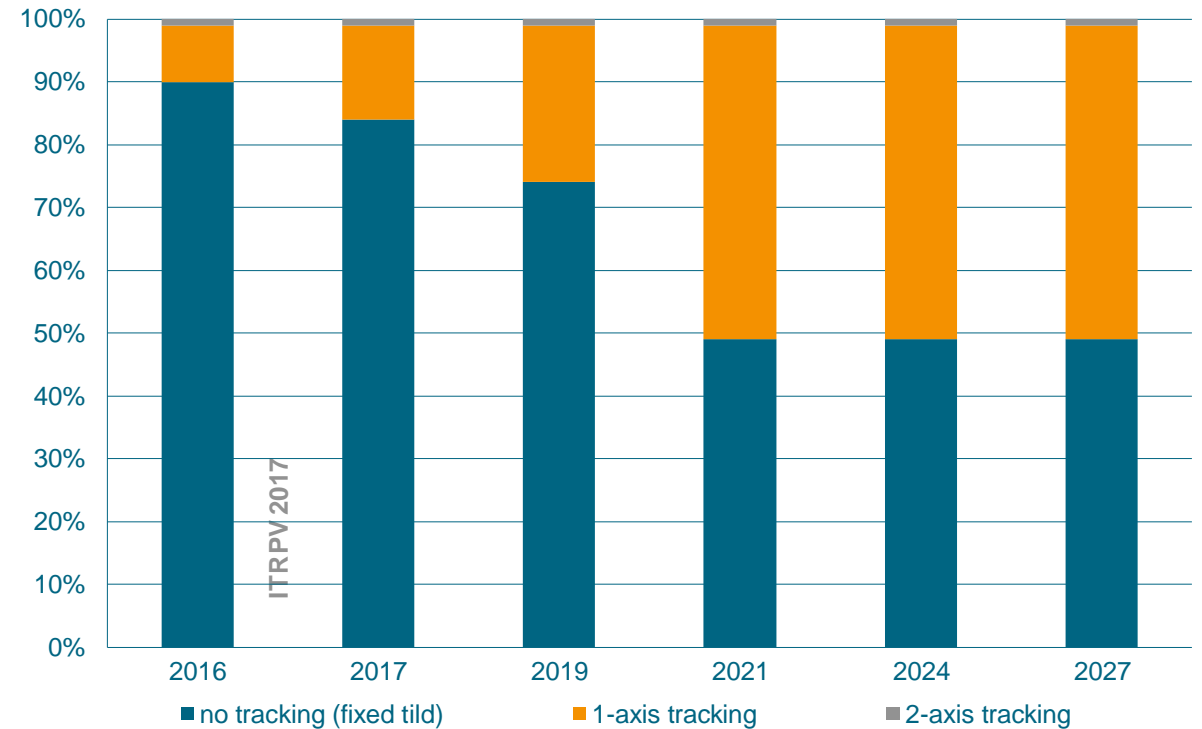
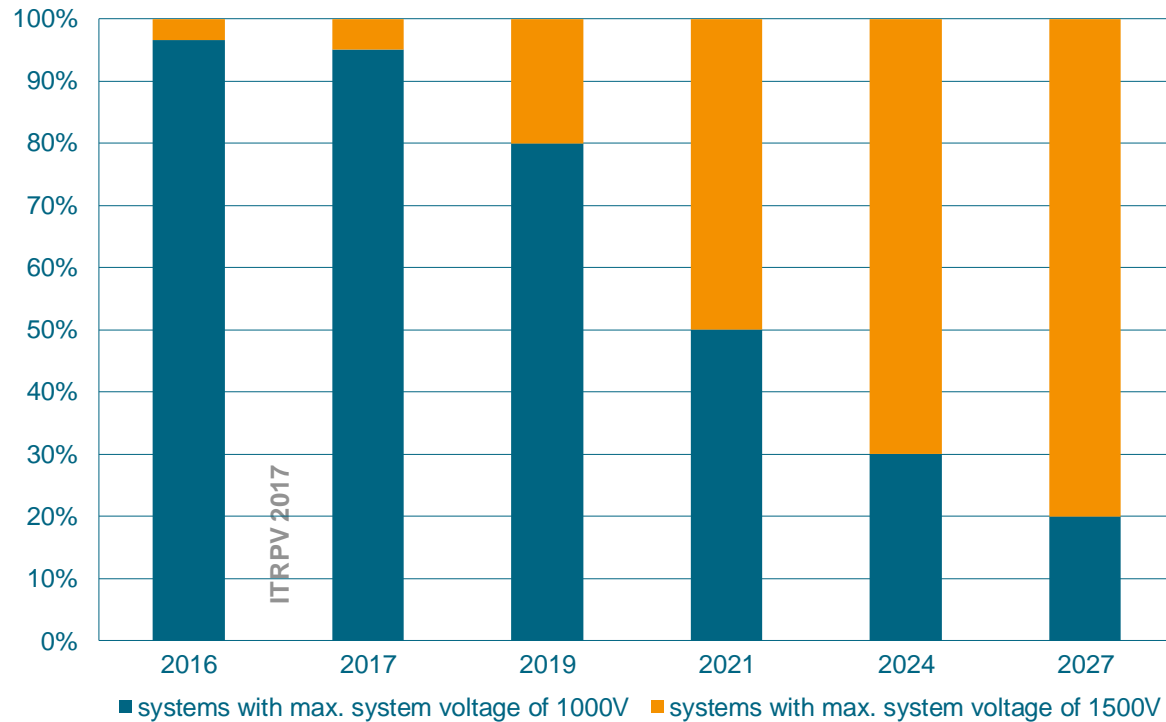
Costs in Asia are assumed to be significant lower

Sstems – Components: system voltage /tracking



Trend: system voltage

Trend: tracker systems in power plant applications



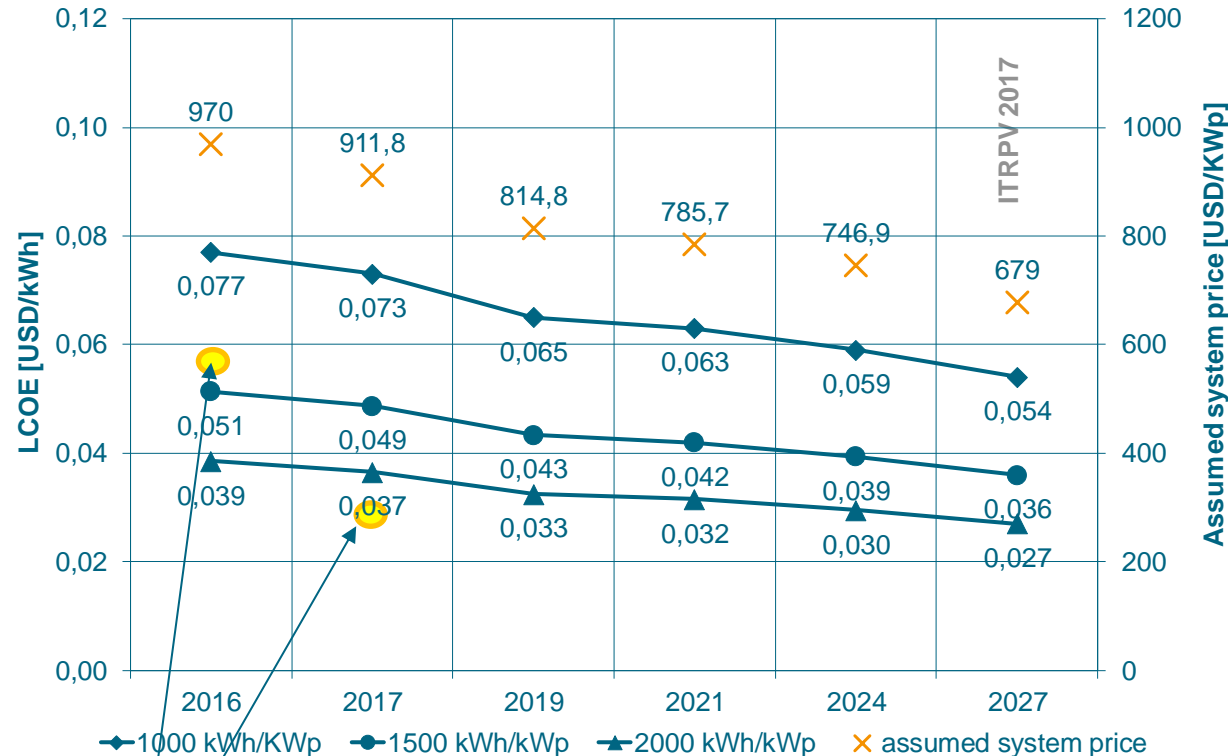
1500V are the future

1-axis trackers will gain market share

Systems – Levelized Cost of Electricity (LCoE)



Trend: LCoE progress – a minimum approach



System prices

→ 2016: 970 \$ / kWp

→ 2027: <680 \$ / kWp



LCoE

→ 2016: 3.9 8 \$ct/kWh (GER avg. 7.7 \$ct**)

→ 2027: 2.7 5 \$ct/kWh are realistic

- System live times of 25 years are assumed

Next steps to further reduce LCoE:

- extended **service life to 30 years**
(supported by performance warranty trend)
- further efficiency improvements
+ cost down measures

LCoE depends strongly on local conditions

→ ~5.7 US\$ct/kWh lowest auction bidder in GER 2016** (avg. 7.7 \$ct)

→ ~2.42 US\$ct/kWh possible near Abu Dhabi* today

* <http://www.pv-tech.org/news/jinkosolar-in-deal-to-build-1.2GWp-solar-plant-in-Abu-Dhabi>

** <http://www.sunwindenergy.com/photovoltaics/danish-bidders-win-cross-border-pv-tender>

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Outlook: in detail view at PV learning curve

1976-2016: LR= 22.5%
 2006-2016: LR= 39.0%

ITRPV finding 2010-2016:

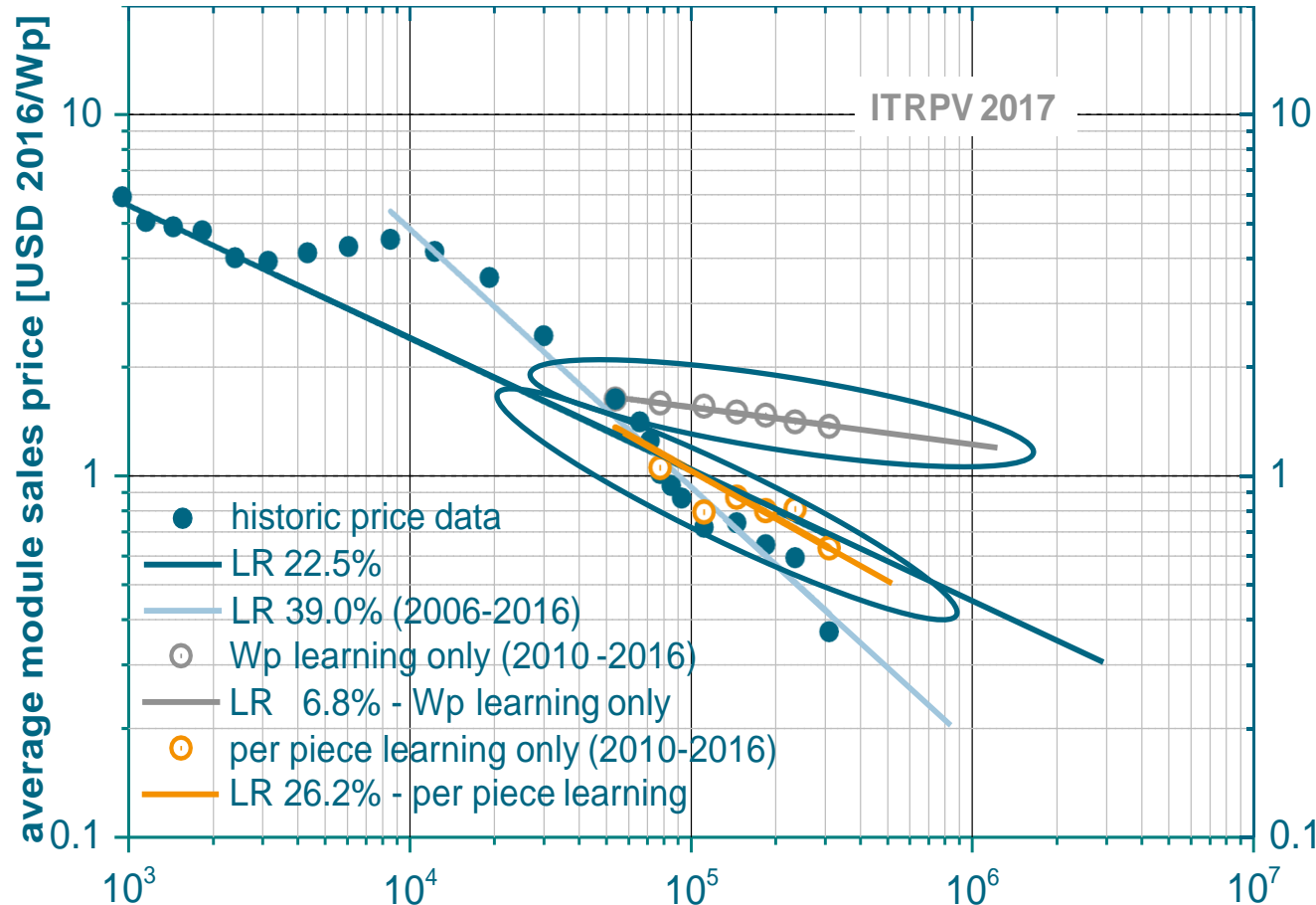
Wp learning ~ 7% (continually)
per piece learning ~26% (market influenced)

→ Learning was and will always be a combination of:

efficiency increase
+ continues cost reduction per piece
= cost reduction of PV generated electricity

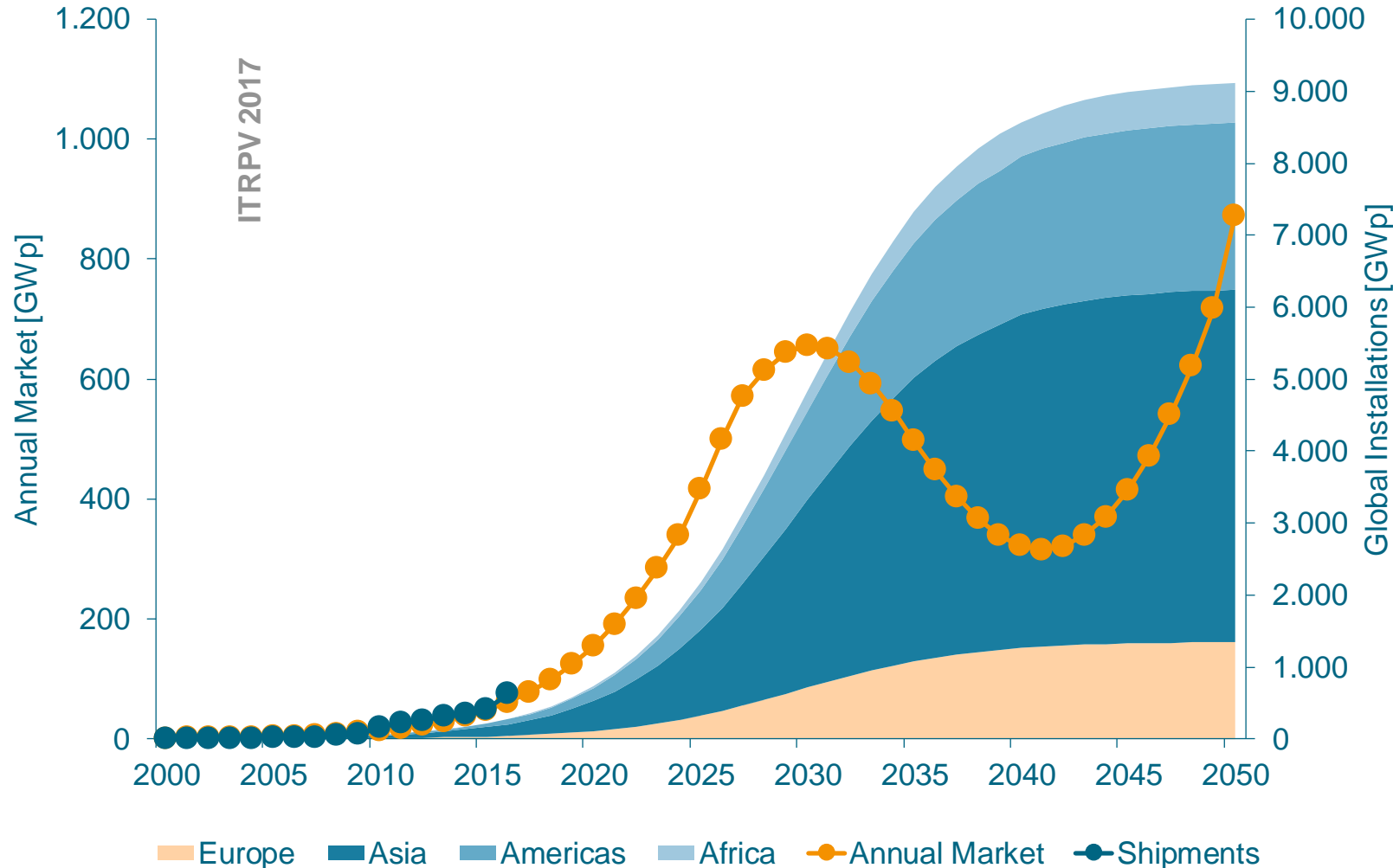
But how will PV proceed in future?

Approach: **logistic growth**



PV market trend until 2050: logistic growth

Scenario 3 “high”: 9.2 TWp/ 14.3 PWh (< 10 % primary energy)



Approach: 3 scenarios for 190 different countries in 4 regions
Asia / America / Africa / EU

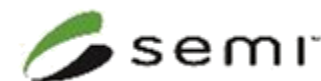
ITRPV finding:

- Shipments until 2016 slightly above all scenarios
- Annual PV market: **335 GWp/a to 800 GWp/a**
- **Replacement rate = key to overcome down cycles**
- **Evolutionary technology development works for all scenarios**

Summary



- **Silicon PV will remain a fast (evolutionary) developing technology**
 - **Further reductions of c-Si PV manufacturing cost are possible**
 - **Cell efficiency improvements will support significant LCoE reductions**
 - **Quality and reliability of components and systems are of highest importance**
- => Silicon PV will significantly contribute to future power supply**
- => We are just at the beginning of PV-market development**



Thank you for your attention!

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